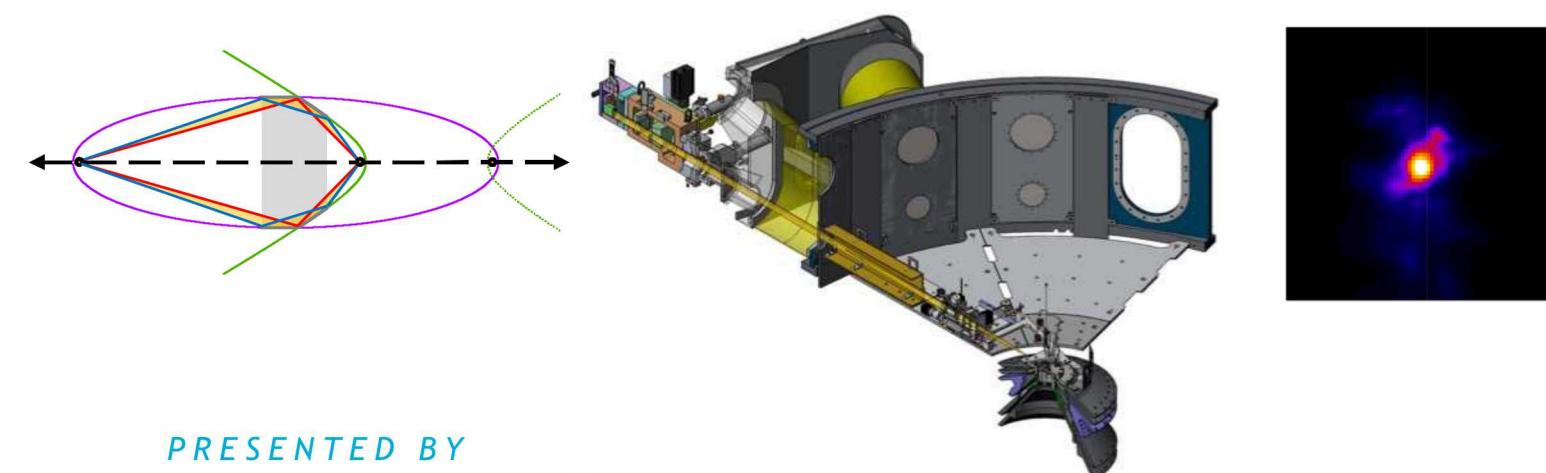




Development of a Wolter Imager to diagnose warm x-ray sources on the Z Machine



PRESENTED BY

Jeff Fein, on behalf of the Wolter team

SNL Z Machine Diagnostic Workshop, April 17-18, 2019



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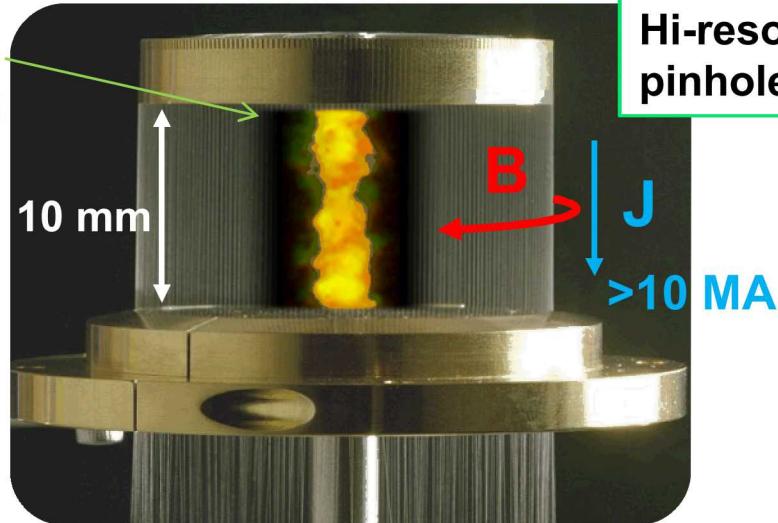
[Universities Space Research Association](#)

B. Ramsey

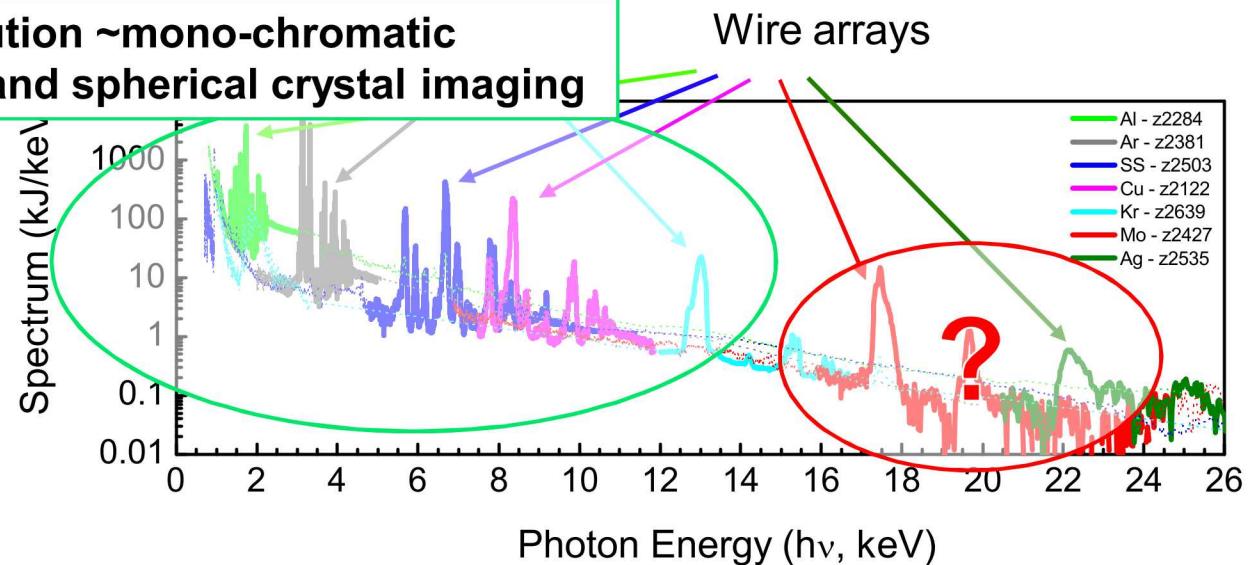
[NASA Marshall Space Flight Center](#)

The Wolter optic was developed to image warm K-shell x-ray sources¹ for radiation effects science (RES) on the Z Machine

<5 keV
pinhole
images²



Hi-resolution ~mono-chromatic
pinhole and spherical crystal imaging

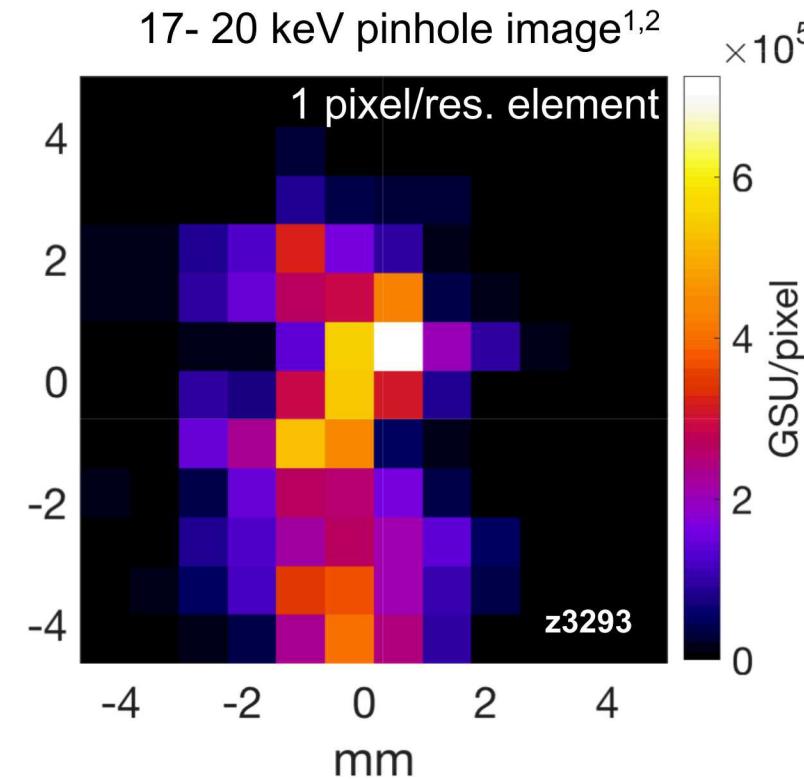
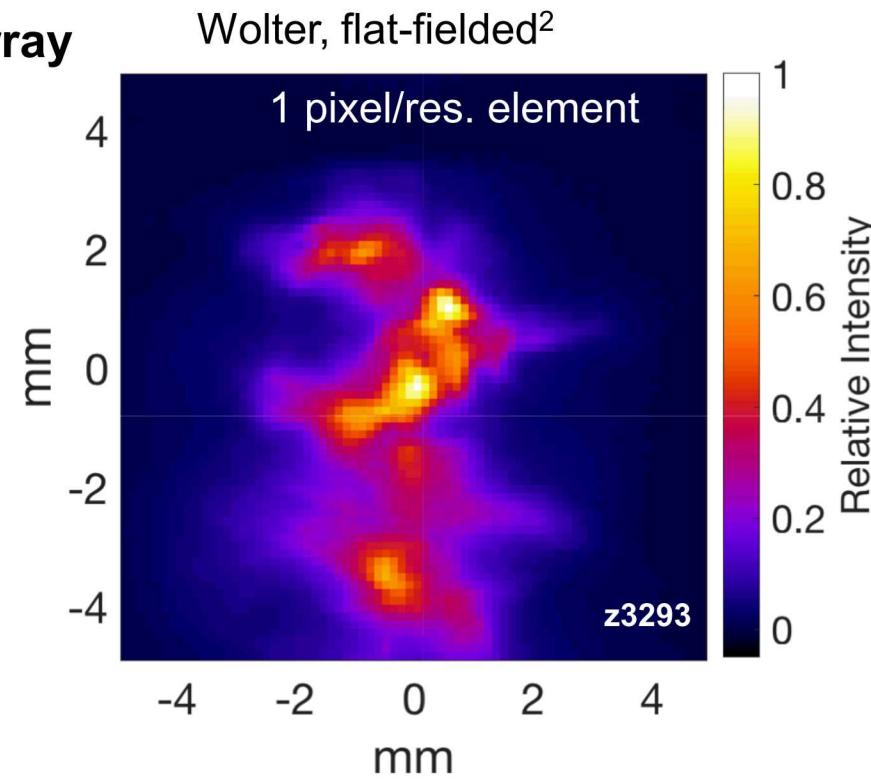


Previous limitations:

- Tradeoff between signal/noise and spatial resolution (e.g. pinhole camera)
- Low efficiency and strong aberrations at >15 keV photon energies (e.g. spherical crystal imaging)
- Small fields-of-view (FOV), sources << 5 mm (e.g. KB microscope, Penumbral imager)

The Wolter optic was developed to image warm K-shell x-ray sources for radiation effects science on the Z Machine

Mo wire-array
z-pinch



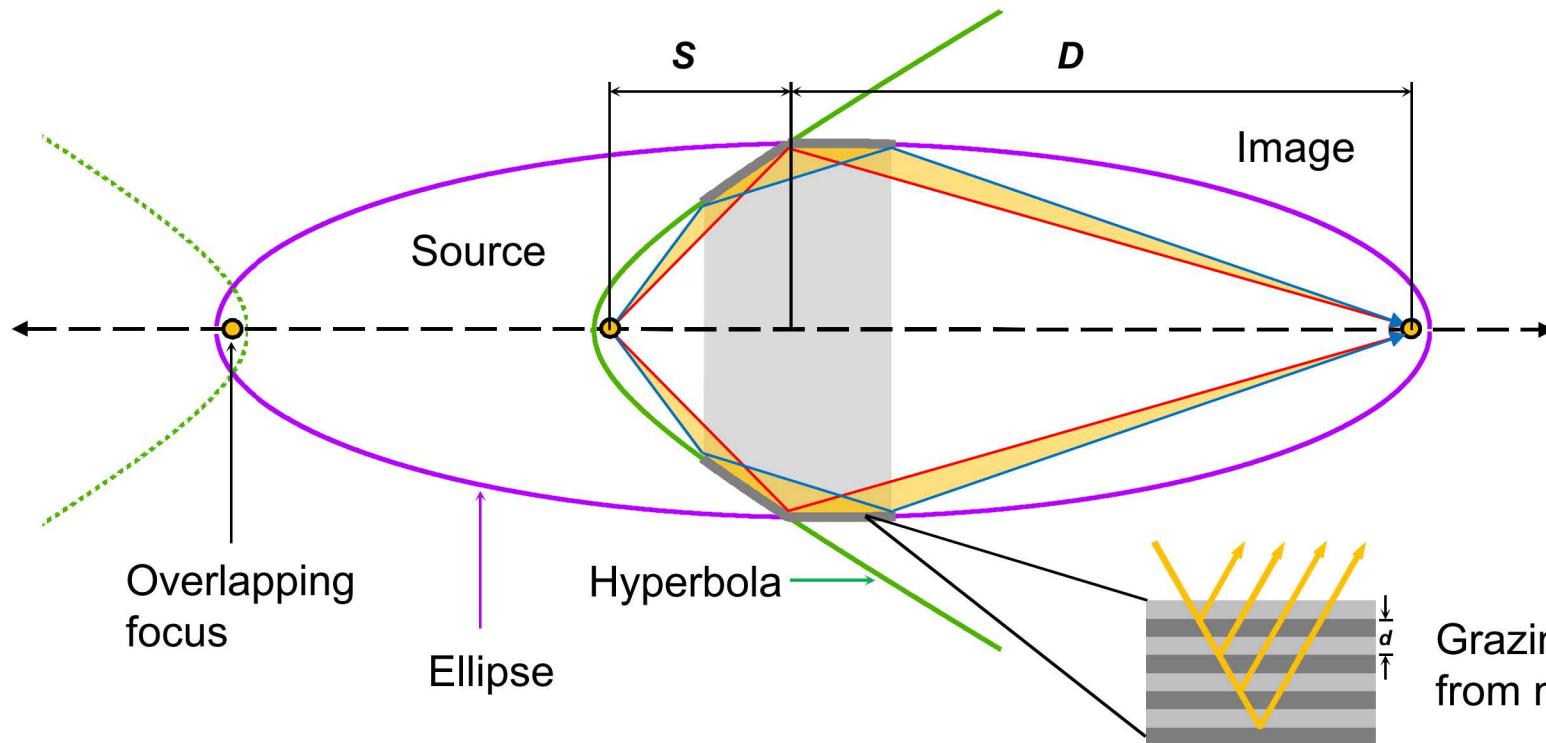
Wolter optics can overcome several limitations from previous techniques for hi-resolution imaging of large (>5 mm) sources at >15-keV

Summary

- The Wolter Imager has successfully imaged x-ray sources on the Z Machine in the 17-18 keV energy band, with development at ~22-keV
- Wolter has demonstrated a spatial resolution better than 150 microns with high signal/noise, significantly improving upon previous imaging capabilities
- Image processing techniques show potential to recover sub-resolution features in recorded images
- New fabrication techniques have been developed, capable of producing even higher-resolution optics

Wolter optics¹ use grazing incidence mirrors to form images of x-ray sources

Wolter type-I microscope:



Optic behaves like lens:

$$\frac{1}{f} = \frac{1}{s} + \frac{1}{D}$$

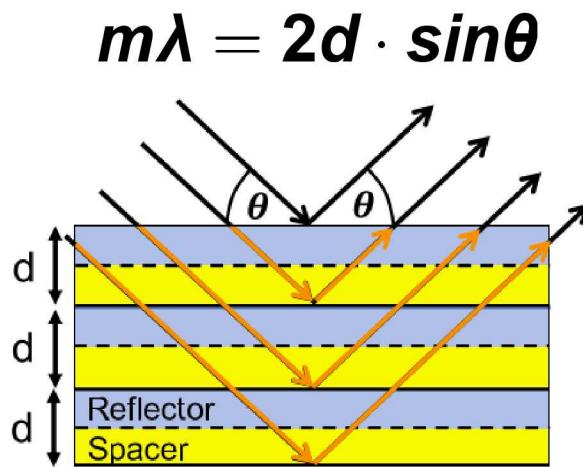
Grazing incidence reflection from multilayer mirrors

Key advantages:

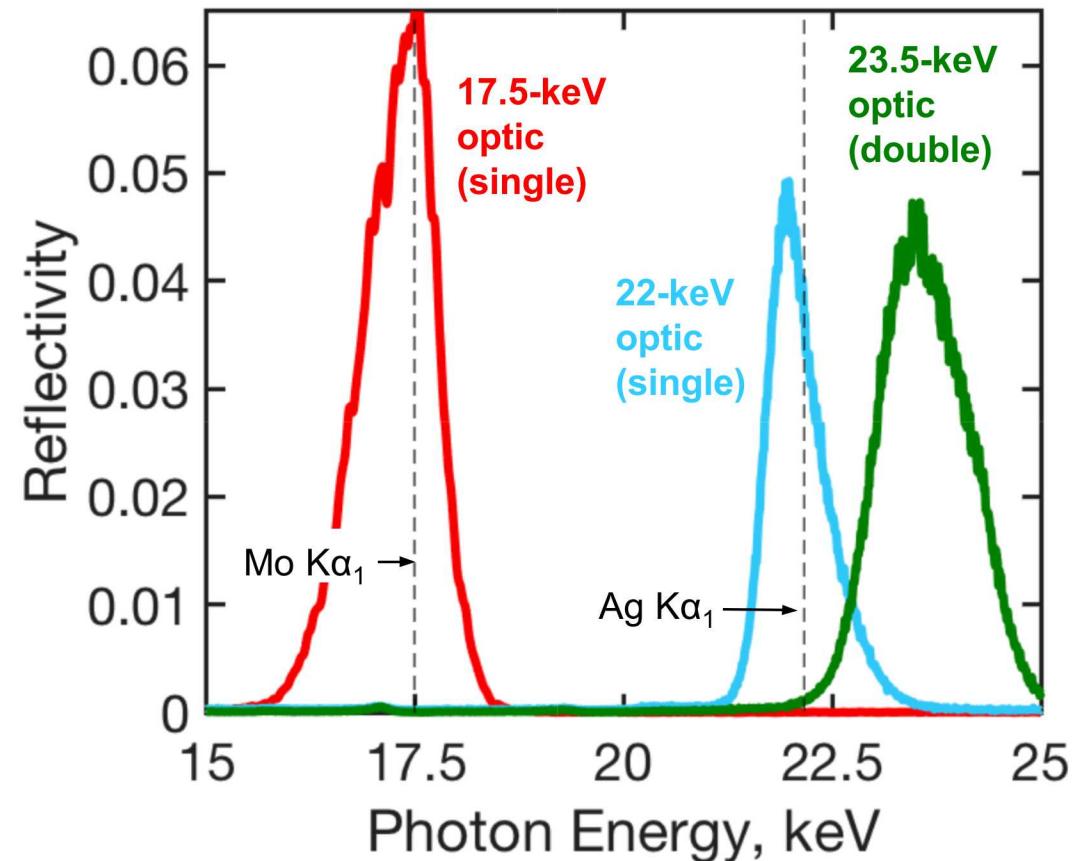
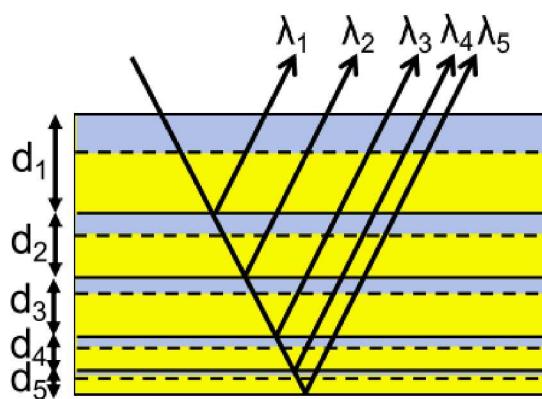
- Large FOV, good resolution off-axis
- Large solid angle, multilayer (high-energies)

Multilayer mirrors enable high-efficiency imaging of >15 keV sources with tunable band-pass

Constant-d¹:

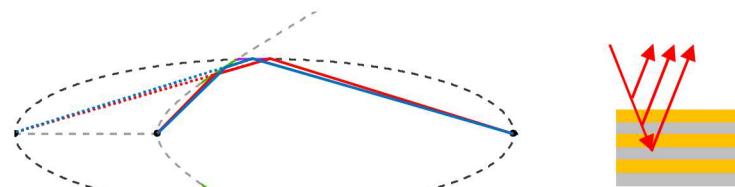


Graded-d:



The Wolter Imager at SNL has been a multi-year collaboration between several institutions

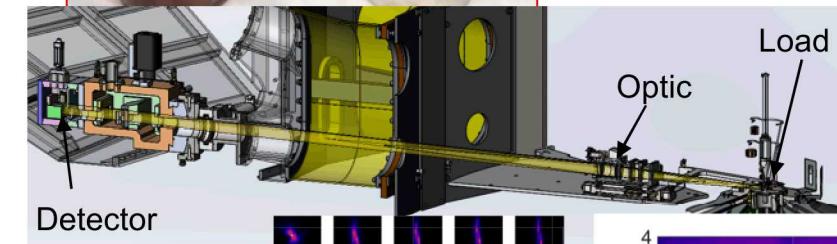
Optical design (LLNL):



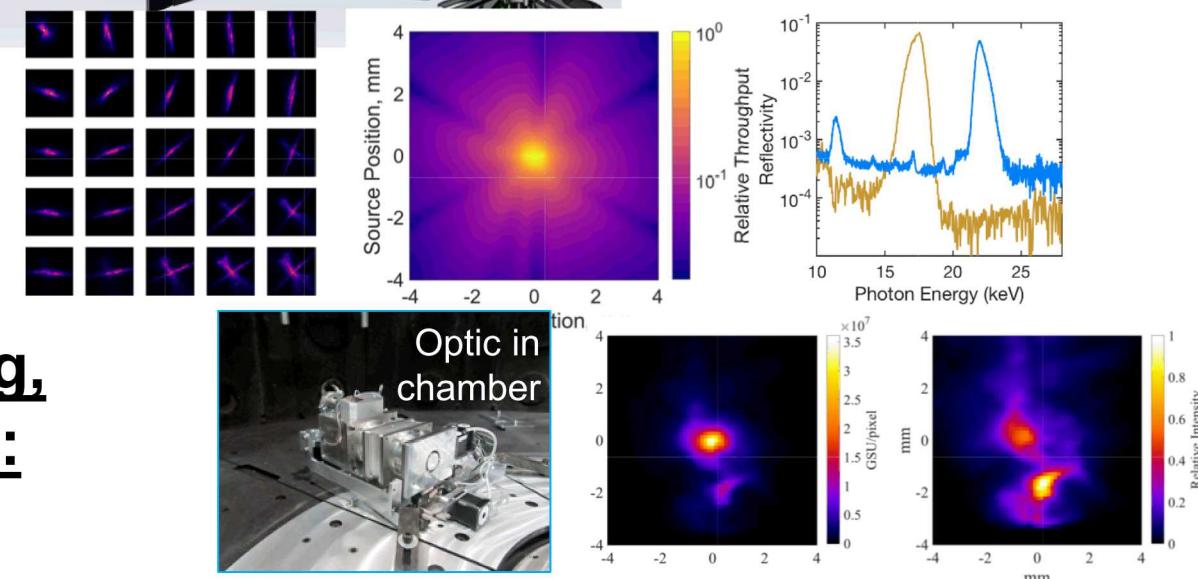
Mandrel & multi-layer fabrication (NASA/Harvard):



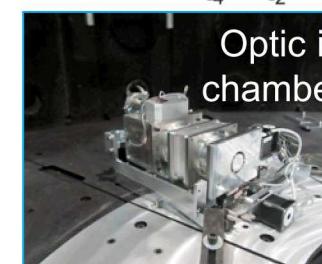
Mechanical design and control systems (SNL):



Calibration (LLNL and SNL):



Commissioning, Fielding, Image processing (SNL):



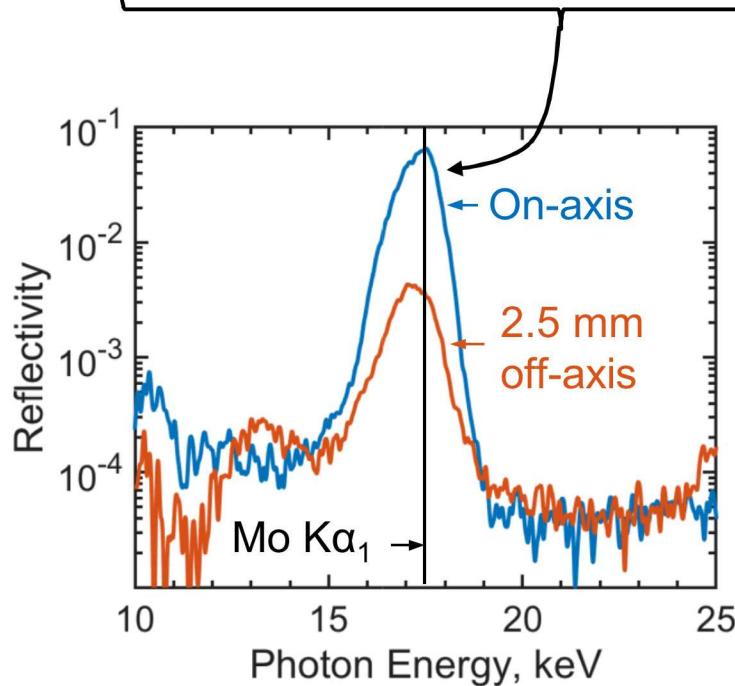
The optic's design was driven by a requirement to produce ~monoenergetic images at >15 keV energy with 100- μ m resolution

#	Need	Goal for initial fielding	Future aim	Driver
1	Photon energy	Mo K α : 17.479 keV	Ag K α : 22 - 23 keV (demonstrated) W K α : 59.32 keV	Study K-shell radiators from Ag to W
2	Spectral window	~1 keV		Simultaneously view K α 1 & 2 from cold and low-ionization states up to He α
3	Field of View	>5 mm field of view (in x,y and z)	Evaluate performance and setup for 20 mm	Study sources that are 5x5x5 mm size Collect all emission from 2 cm pinch. K α emission comes from large diameter
4	Spatial Resolution	100 μ m	50 μ m	Resolve length-scale of structures emitting K α (don't know what these are)
5	Time resolution	Time integrated initially	~1 ns in 2-4 years (hCMOS)	Resolve evolution over x-ray pulse
6	Sensitivity	800 J/cm ² at source with 3:1 signal to noise	100 J/cm ² at source with 3:1 signal to noise	Able to record 100 J (over source area); not diminish resolution with noise
7	Contrast	5:1 (In-band/Out-of-band)	>15:1	Image dominated by relevant signal
8	Flatness of response	<3x variation over FOV		Dynamic range of likely detectors (Image plate, hCMOS)

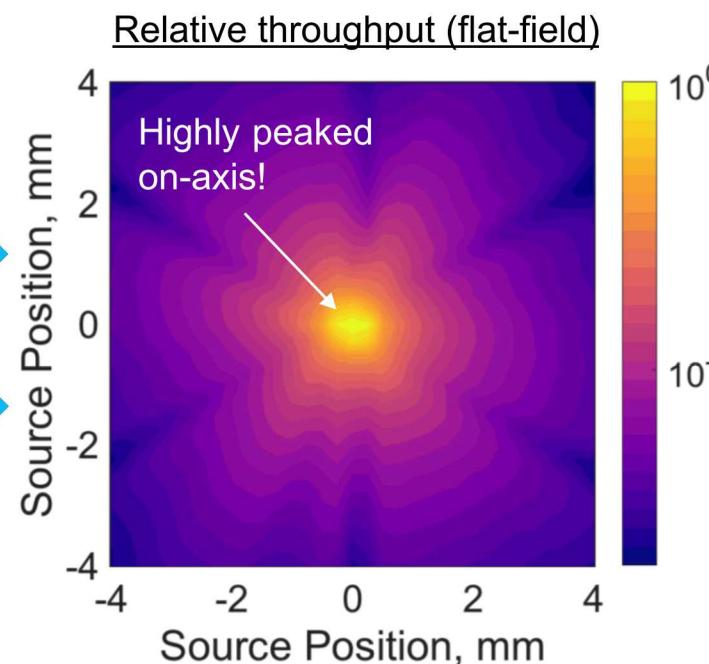
The optic has been characterized extensively in the laboratory to understand its performance and provide measurements for future image processing^{1,2}

Initial 17.5 keV optic:

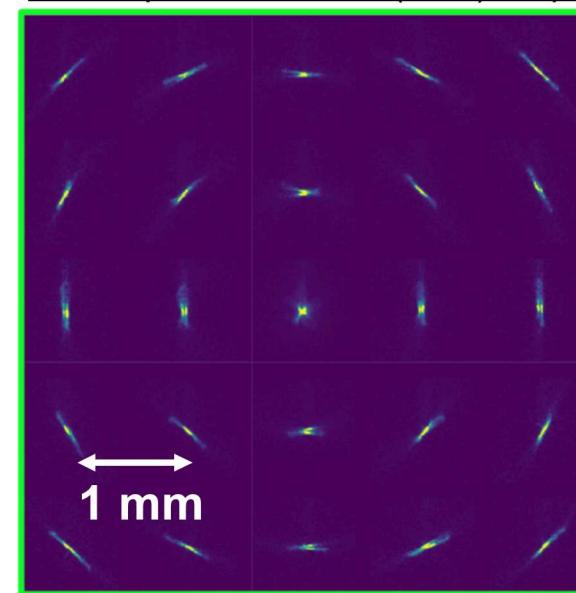
- 75-µm resolution on-axis, 30-µm to 300-µm resolution off-axis
- ~1 keV bandwidth with centroid at 17.3 keV
- In-band/Out-of-band rejection ratio >15:1



$$\int dE$$



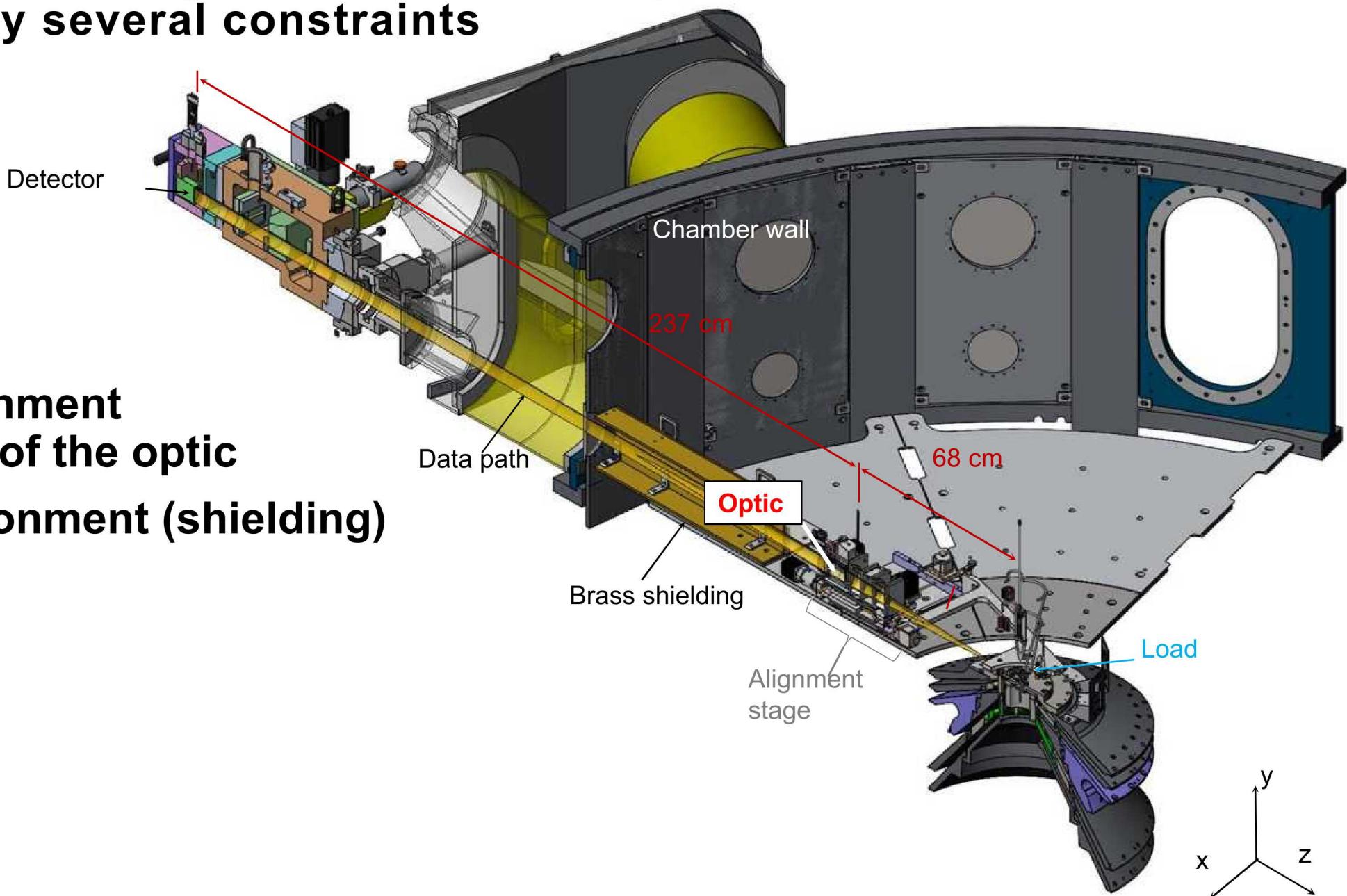
Point-spread function (PSF) map:



Variation of optic's response over FOV makes it very sensitive to alignment!

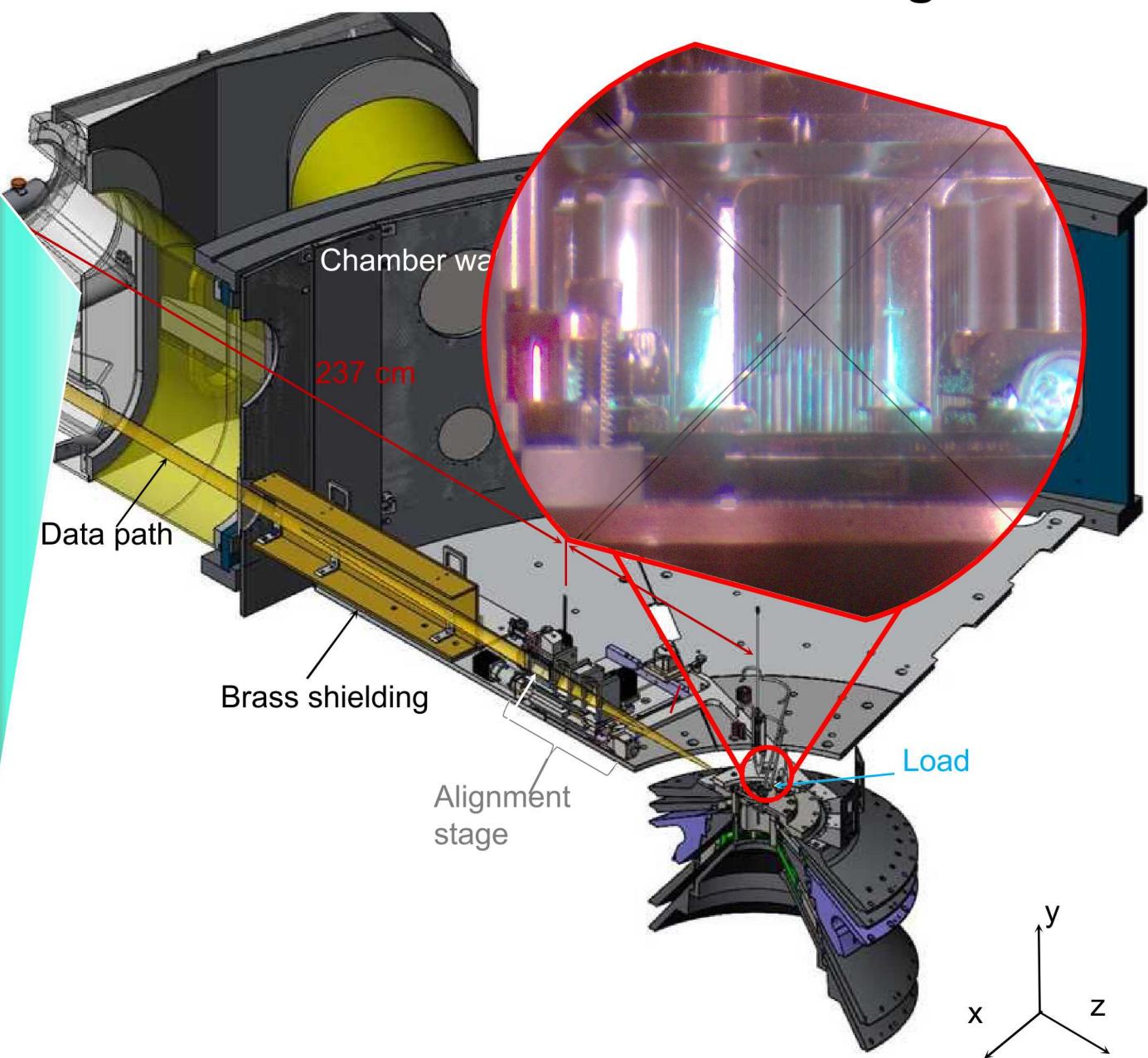
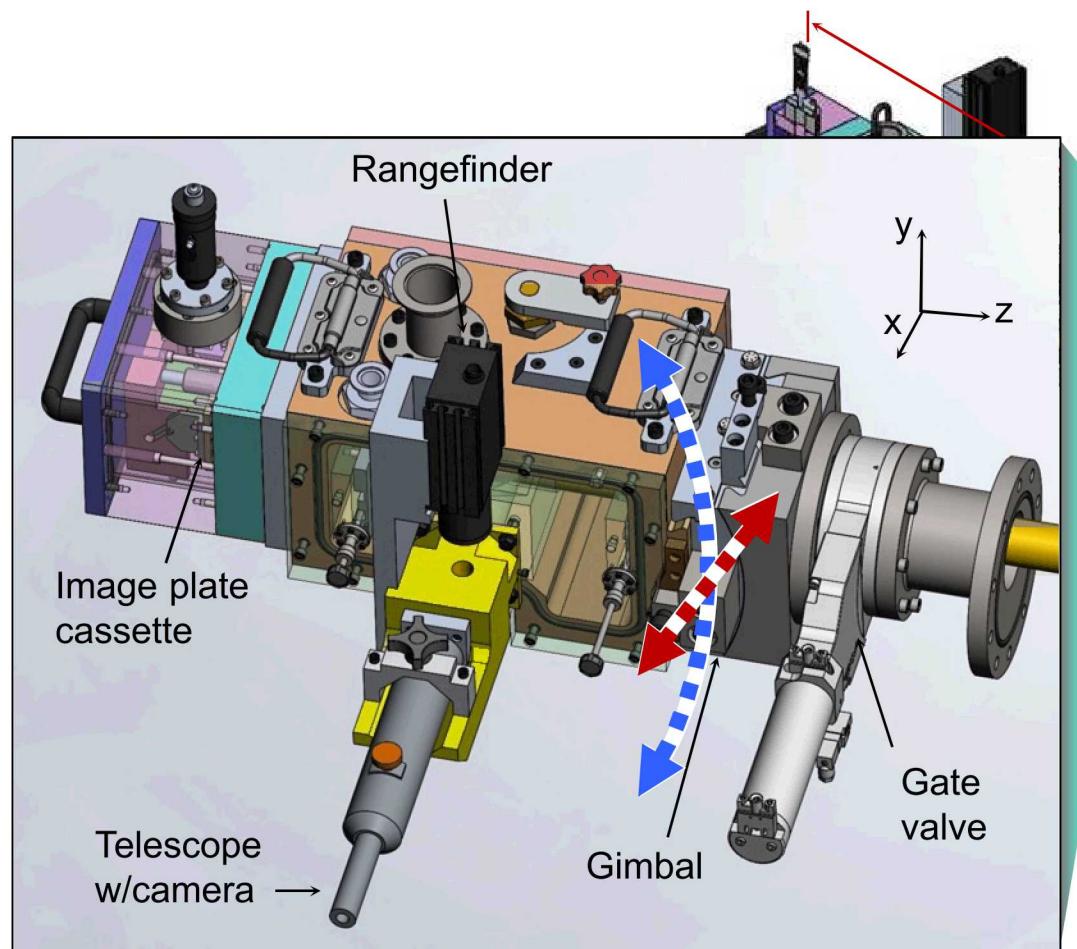
The mechanical design of the Wolter Imager on the Z Machine was driven by several constraints

- Stringent alignment requirements of the optic
- Harsh Z environment (shielding)



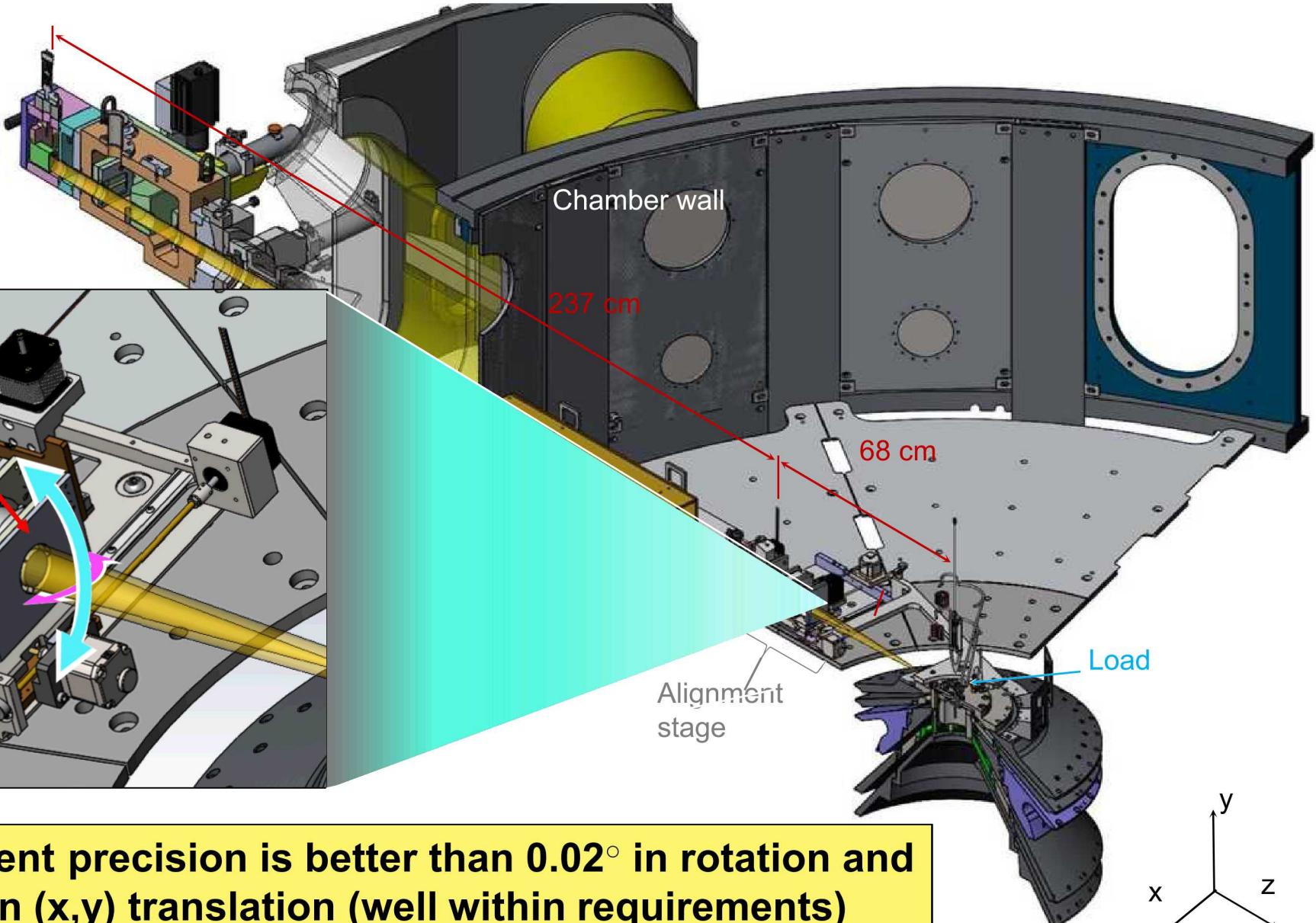
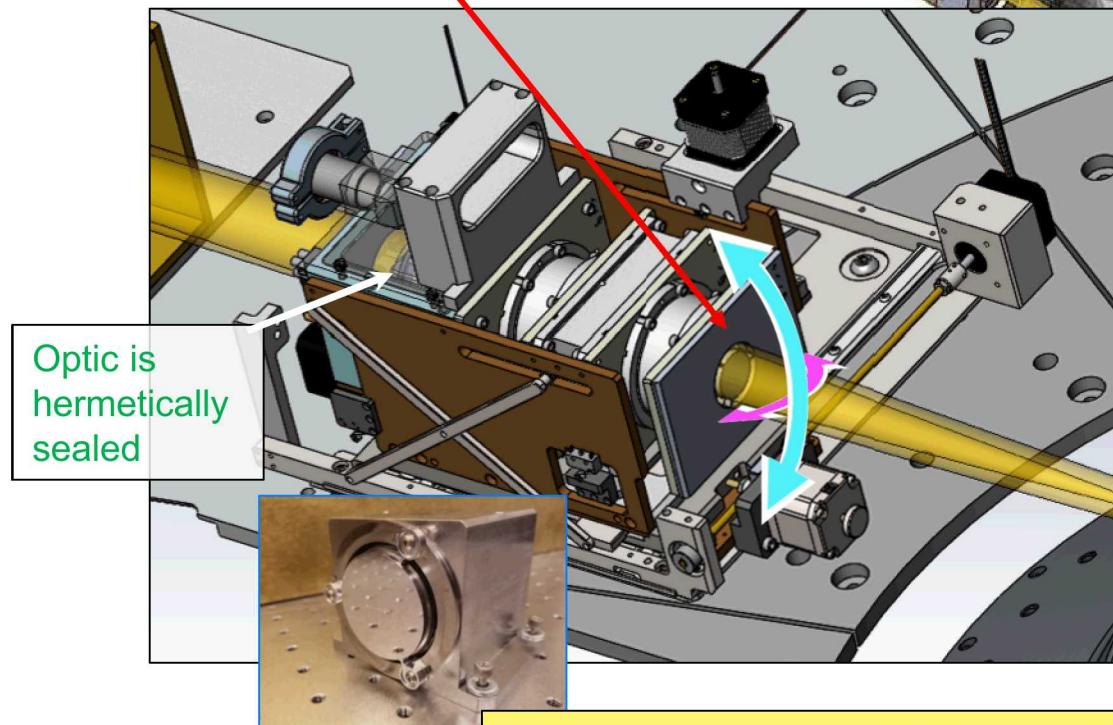
The detector is aligned to the load with a camera and laser rangefinder

12

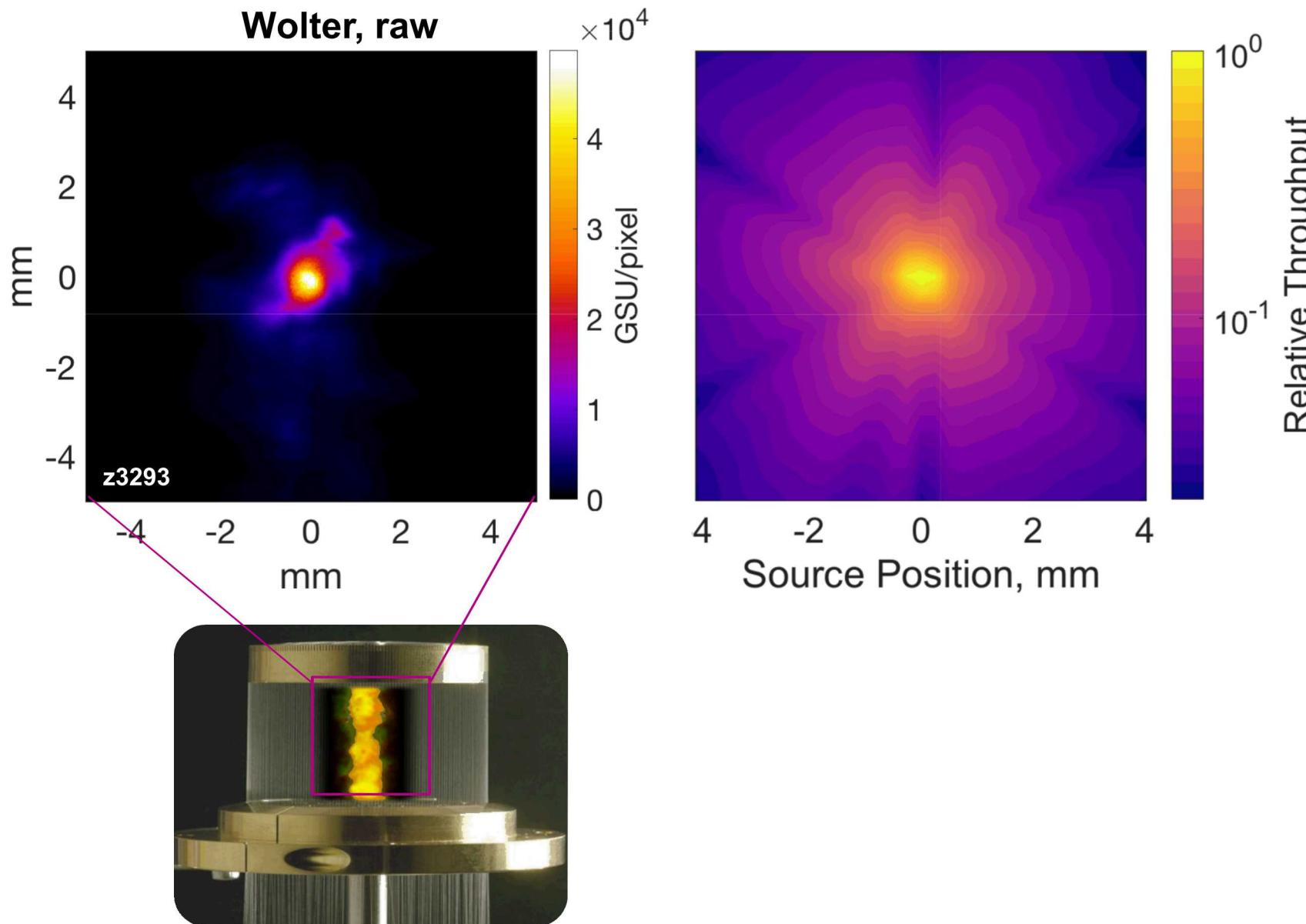


The optic is aligned remotely with a motorized five-axis stage, shielding allows the optic to survive the Z environment

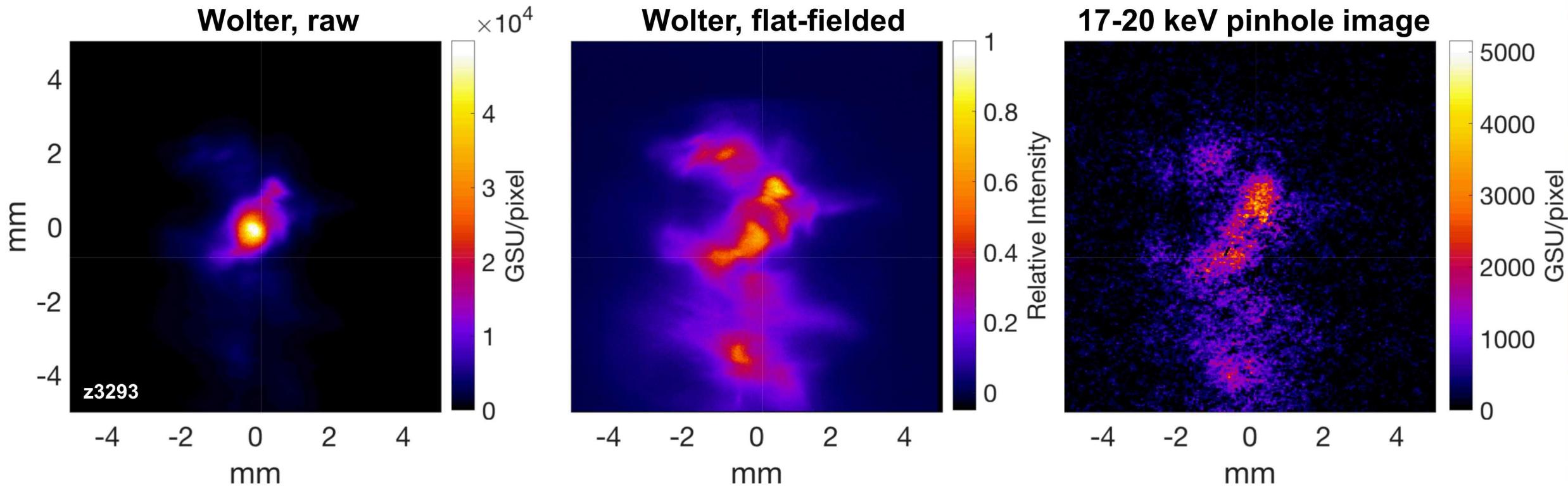
Tungsten baffles/plug block detector from LOS x-ray background & optic from debris (It survives!)



The Wolter imager was successfully fielded on the Z machine, imaging Mo wire array z-pinches¹

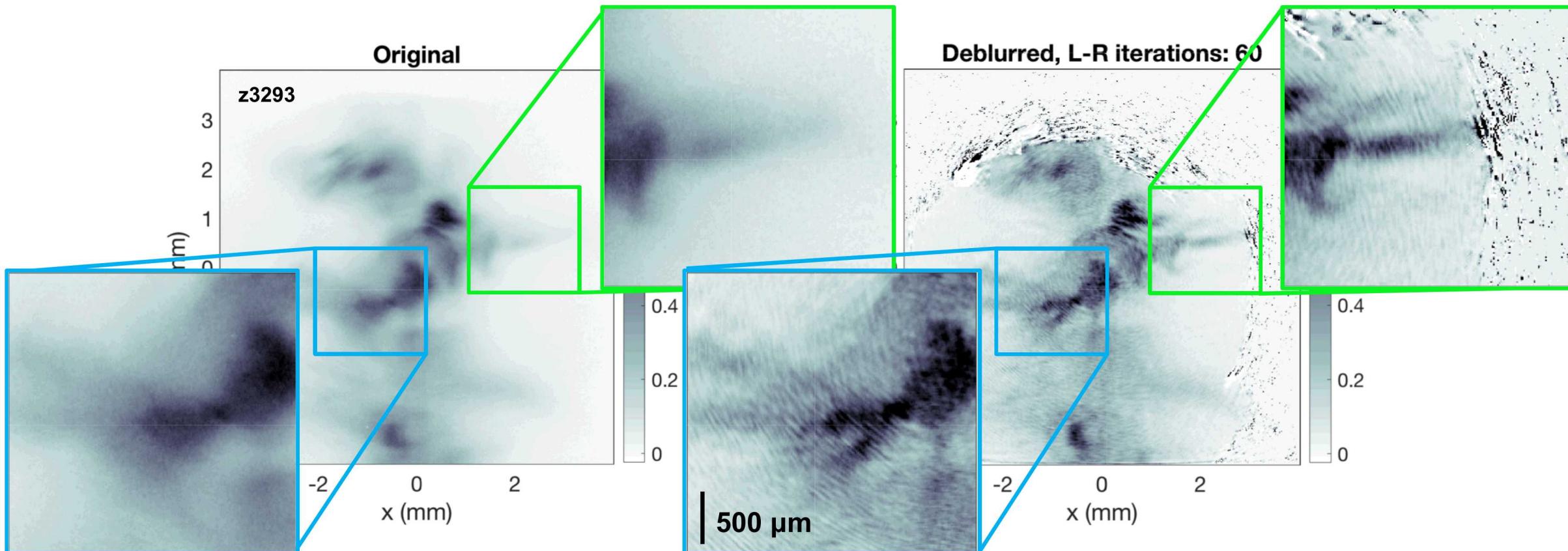


First Wolter images¹ demonstrate drastic improvements in spatial resolution and signal/noise compared to pinhole camera²



- Flat-fielded Wolter images have features similar to those seen in time-integrated pinhole camera² (TIPC) images
- Wolter demonstrates spatial resolution better than 150 μm , compared to $\sim 1 \text{ mm}$ in TIPC, as well as a factor of 19 – 64 increase in signal/noise (helps enable time-resolved)

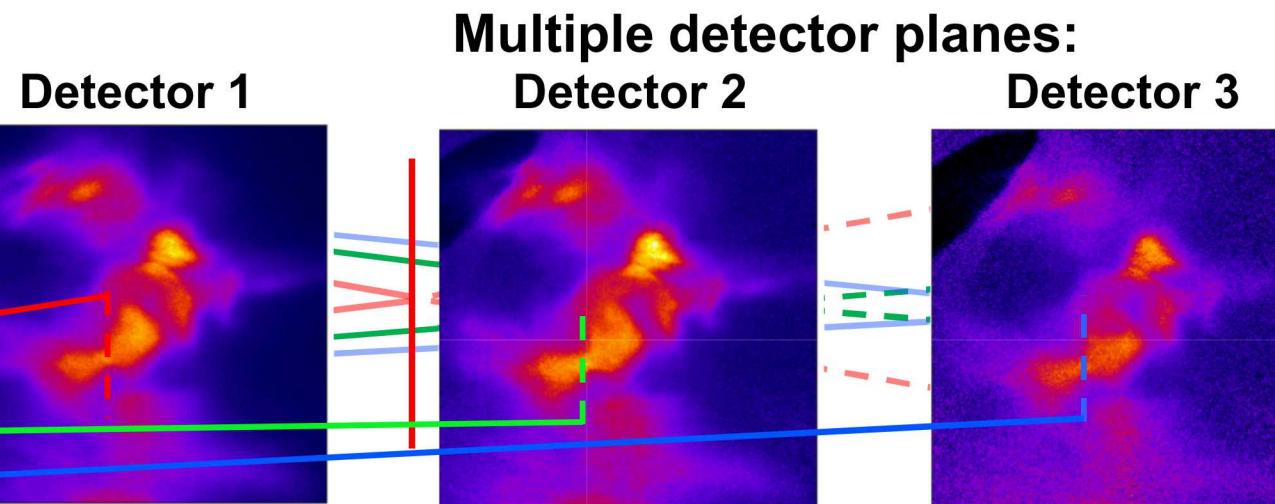
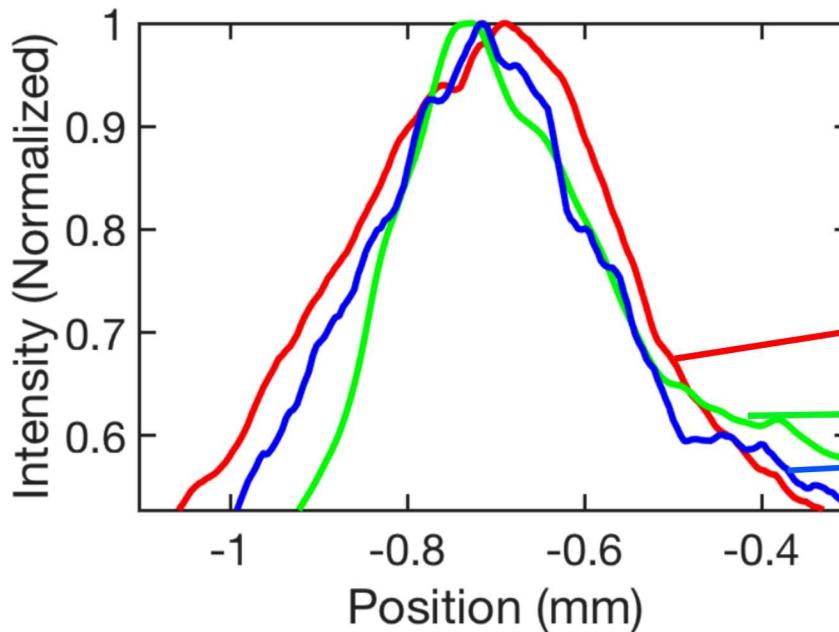
Deblurring of actual Wolter data indicates structures may exist below the resolution limit



- Deblur using **iterative Lucy-Richardson algorithm (maximum likelihood)**
- Image is computed as sum of convolutions after breaking up (measured) shift-variant PSF into shift-invariant modes¹

Real x-ray sources are 3D...i.e. we need to account for depth

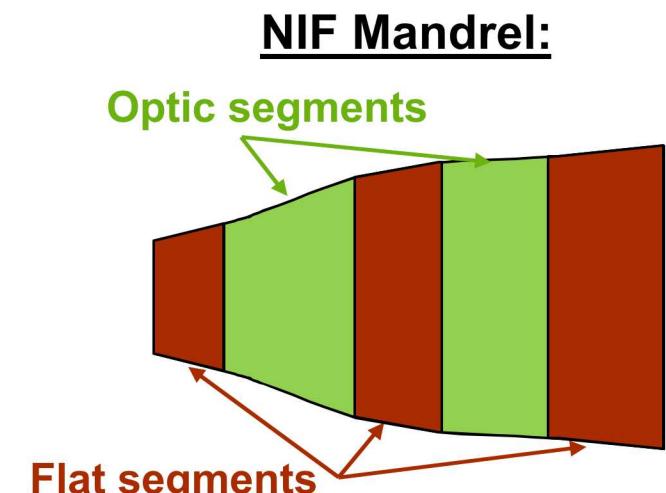
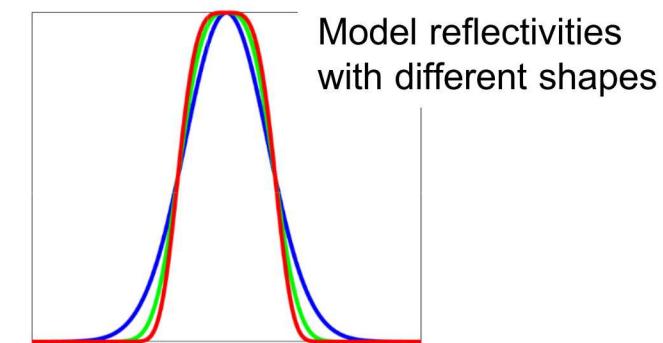
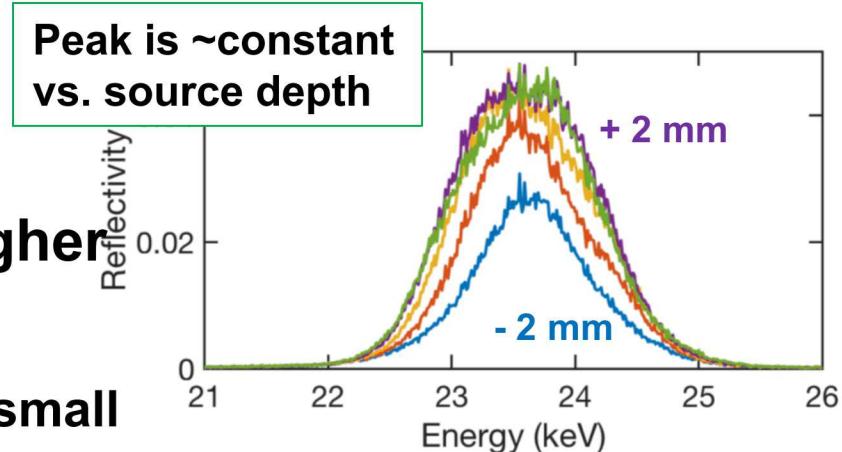
Lineouts from each detector plane:



- Multi-plane detector¹ can help recover depth information
- Synthesize information from spatially and spectrally resolved diagnostics at multiple lines of sight
- Created Wolter image model for 3D sources that incorporates variation in PSF and throughput over entire FOV

Additional next steps

- We are currently developing 22-keV optics for higher energy sources
- New optics have less variation over FOV as a result of small tunings in multilayer recipe and improved replication
- Pursuing new reflectivity shapes to improve In-Band/Out-Band, Signal/Noise, etc.
- Plan to integrate a hCMOS¹ detector for time-resolved imaging (~CY2020-2021)
- Lessons learned from SNL optic are being leveraged to design and fabricate an optic for NIF with even higher resolution
 - Improved polishing and alignment has led to 10x reduction in figure error (optic's shape)
 - Flat segments introduced to mitigate edge curling



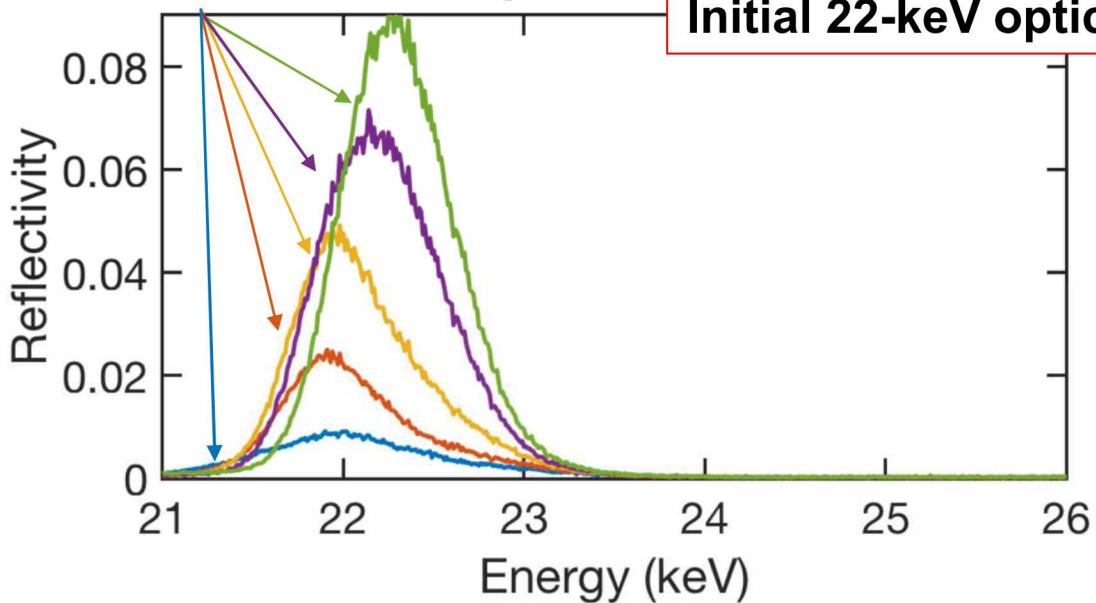
The Wolter optic for the Z Machine is part of an ongoing collaboration to improve x-ray imaging by pushing FOV, resolution and energy

- The Wolter Imager has successfully imaged x-ray sources on the Z Machine in the 17-18 keV at better spatial resolution (~150 μm) and signal/noise than previous capabilities
- Image processing techniques show potential to recover sub-resolution features in recorded images
- Leveraging lessons in fabrication and optic geometry/multilayer design to produce better-performing optics for future applications

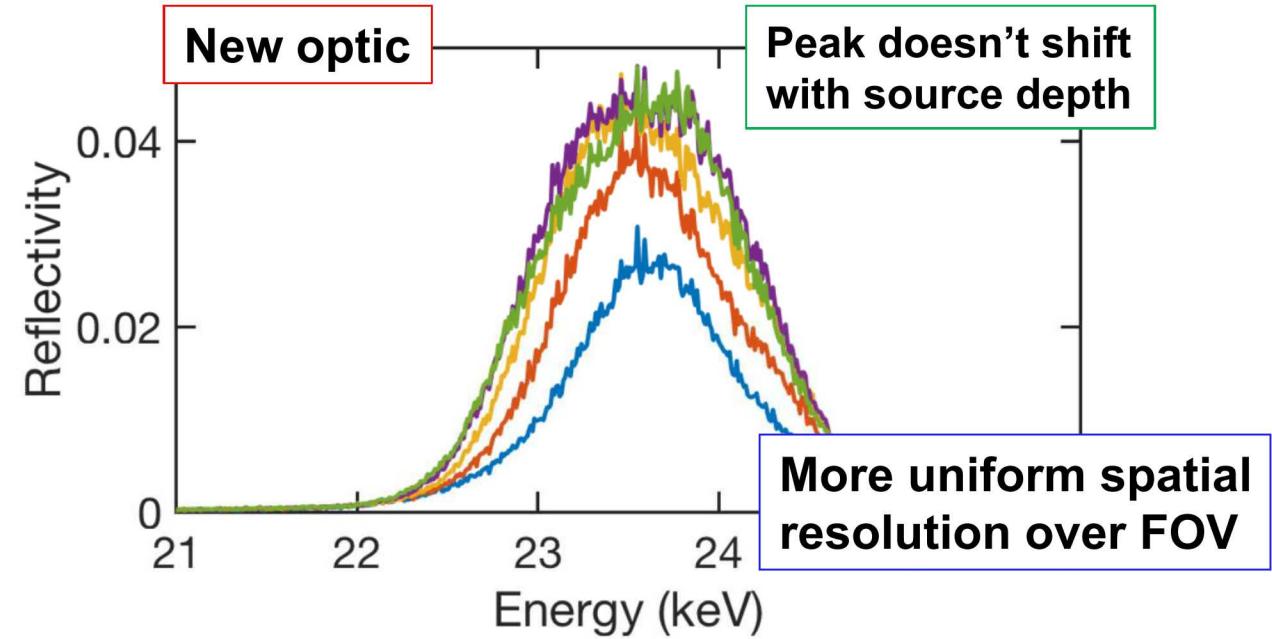
Extra material (although not organized as structured slides)

We are successfully fielding 22-keV optics to image even higher-energy sources

Reflectivities at different source depths:



Initial 22-keV optic



New optic

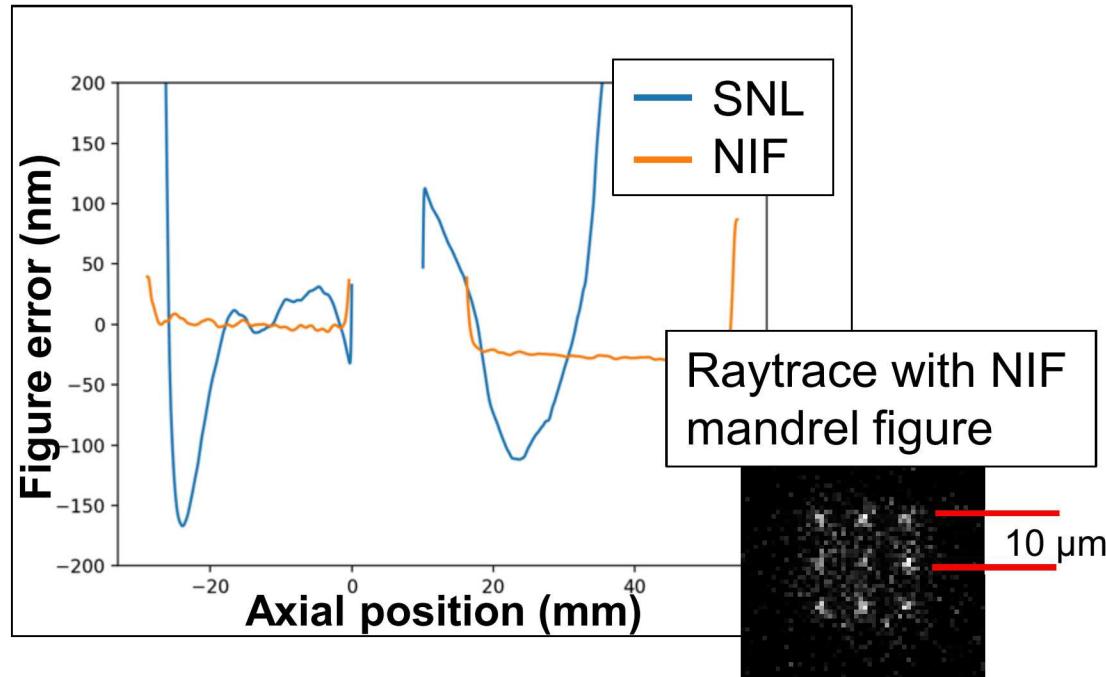
Peak doesn't shift with source depth

More uniform spatial resolution over FOV

New optics have improved performance as a result of small tunings in the multilayer recipe and improved replication

Replicated optic performance is being enhanced by improved polishing and by re-designing the optic's shape

LLNL and NASA MSFC collaborated to improve lap polishing and figure correction of a test NIF mandrel



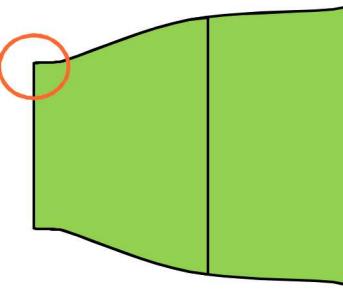
~10x reduction in figure error, expect < 10-μm resolution:

- Lap polishing improvements = 5x reduction
- Improved polishing slurry, alignment procedure for sub-aperture polisher (Zeeko) = 2x reduction

Flat segments introduced on ends/middle of optic to mitigate edge curling during replication

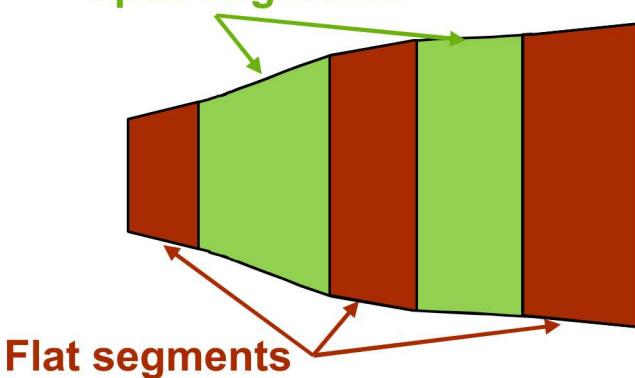
SNL Optic shape:

Edge curling during replication



NIF Mandrel shape:

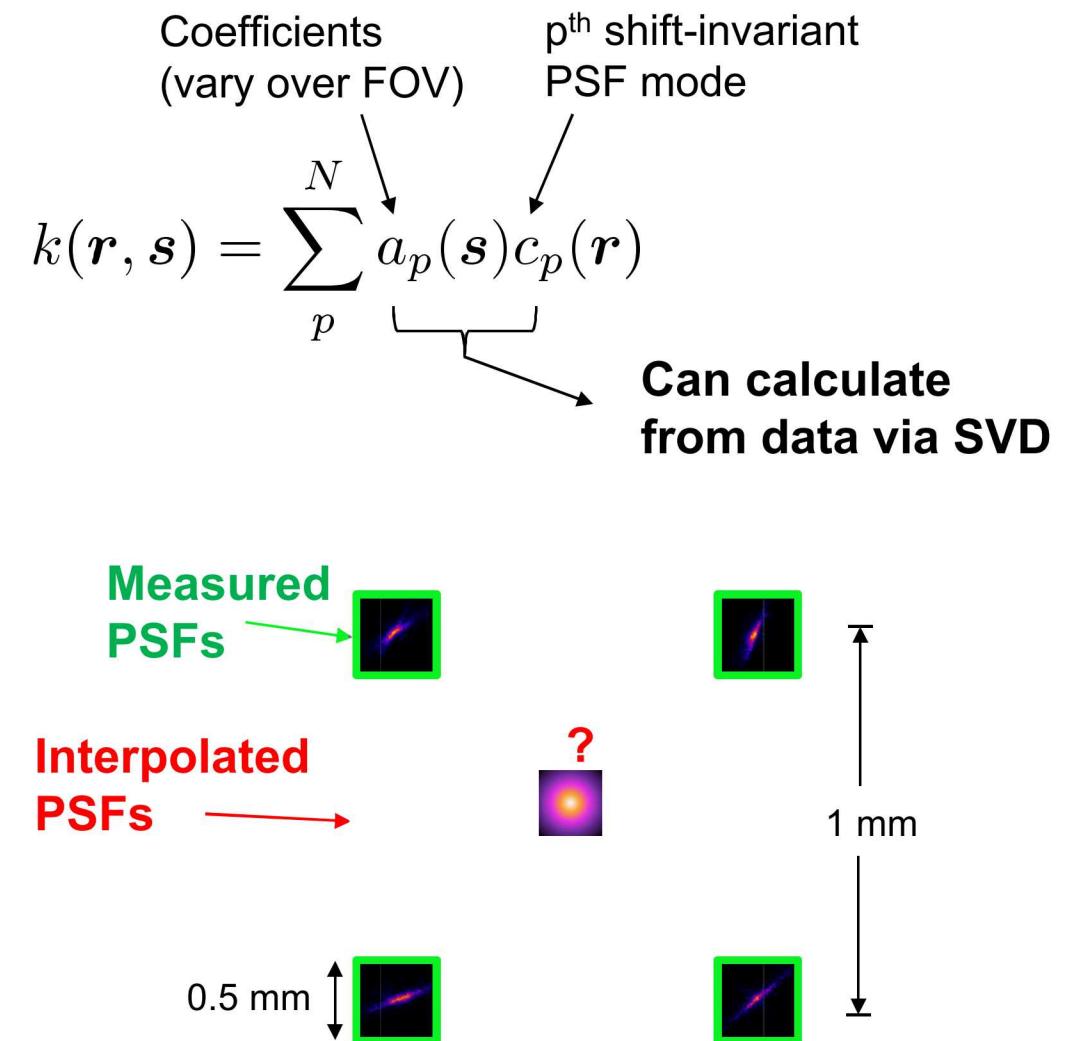
Optic segments



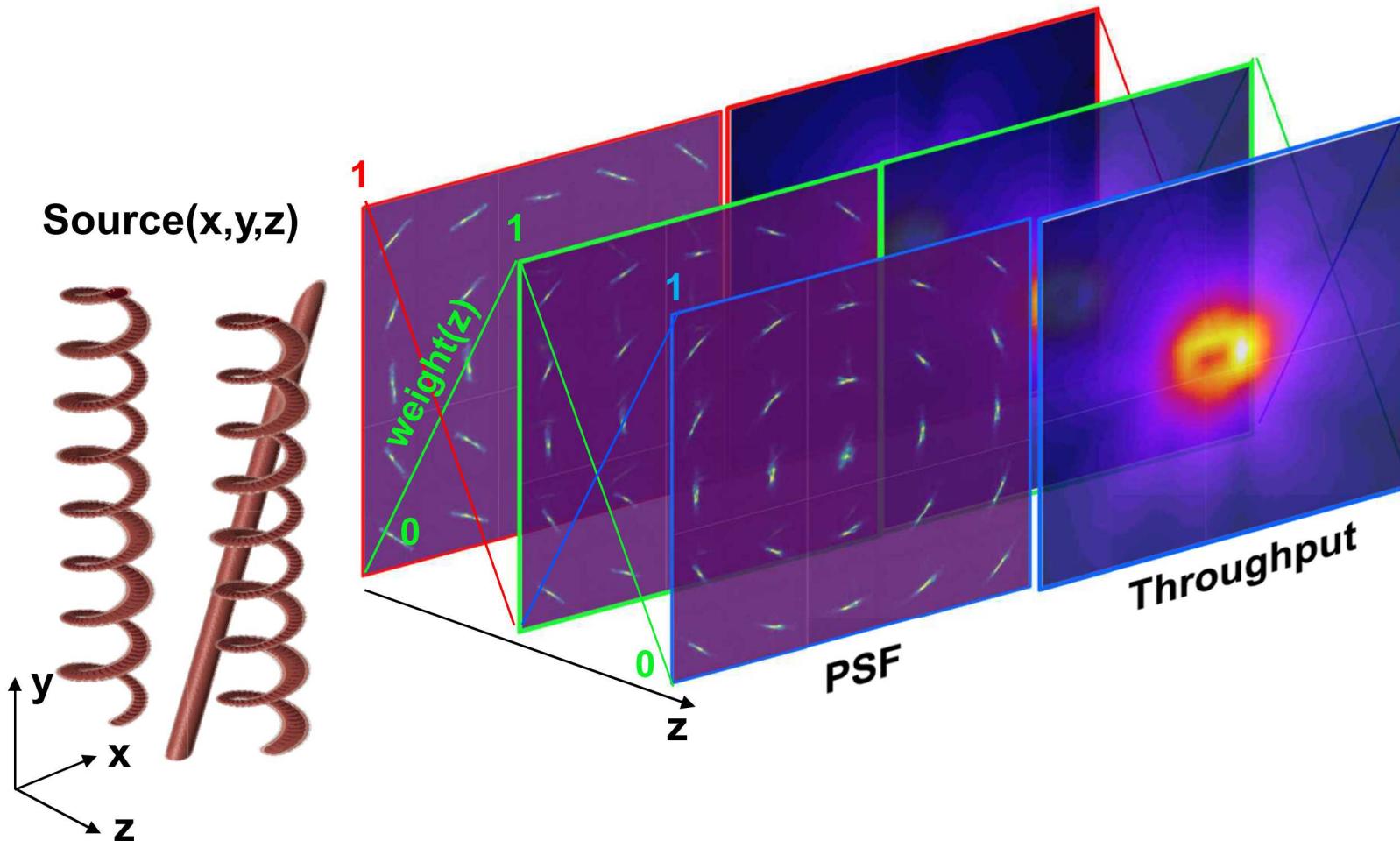
We are beginning advanced image processing to efficiently calculate Wolter images and deblur them

- Shift-variant PS means we cannot do simple convolutions to compute images
- Break up shift-variant PSF into sum over weighted modes, constructed from measured PSF data:
- Image is computed as sum of convolutions over PSF modes after interpolating coefficients at all source positions:

$$\text{Image} = \sum_p^N c_p * (a_p \times \text{Source})$$

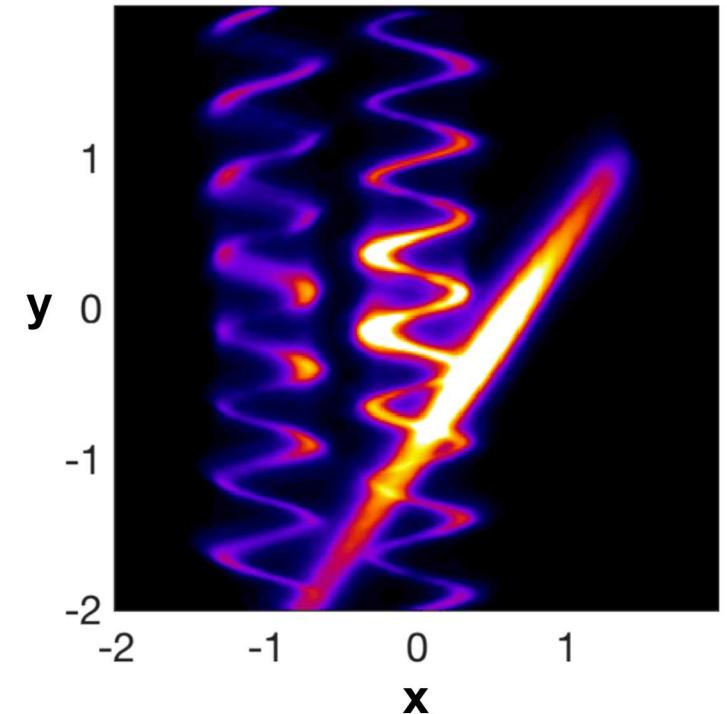


Variation of the optic's response with depth motivates an image model from 3D sources

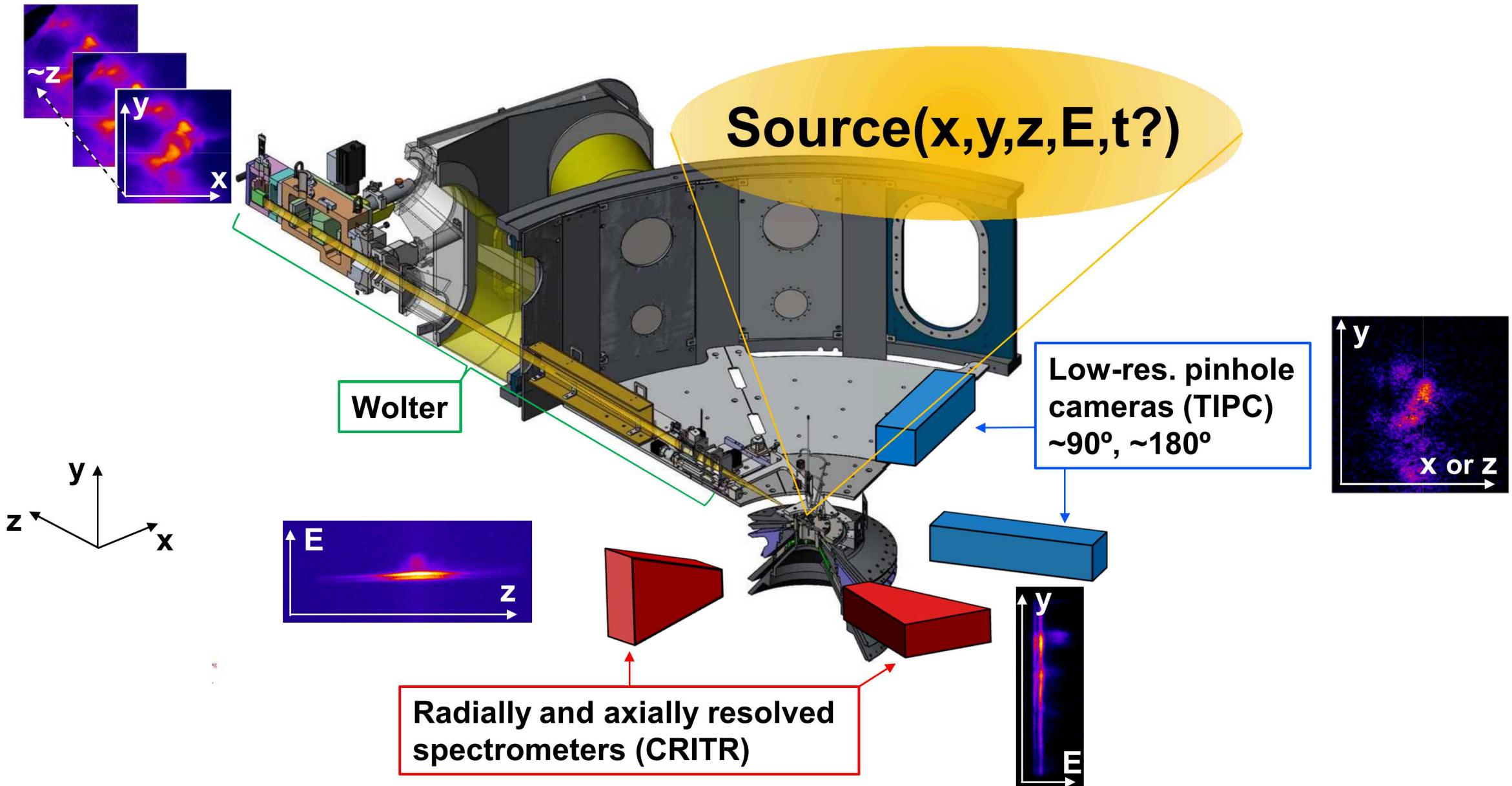


$$\text{Image}(x, y) = \int_z \text{Source}(z) \text{Throughput}(z) \text{PSF}(z) dz$$

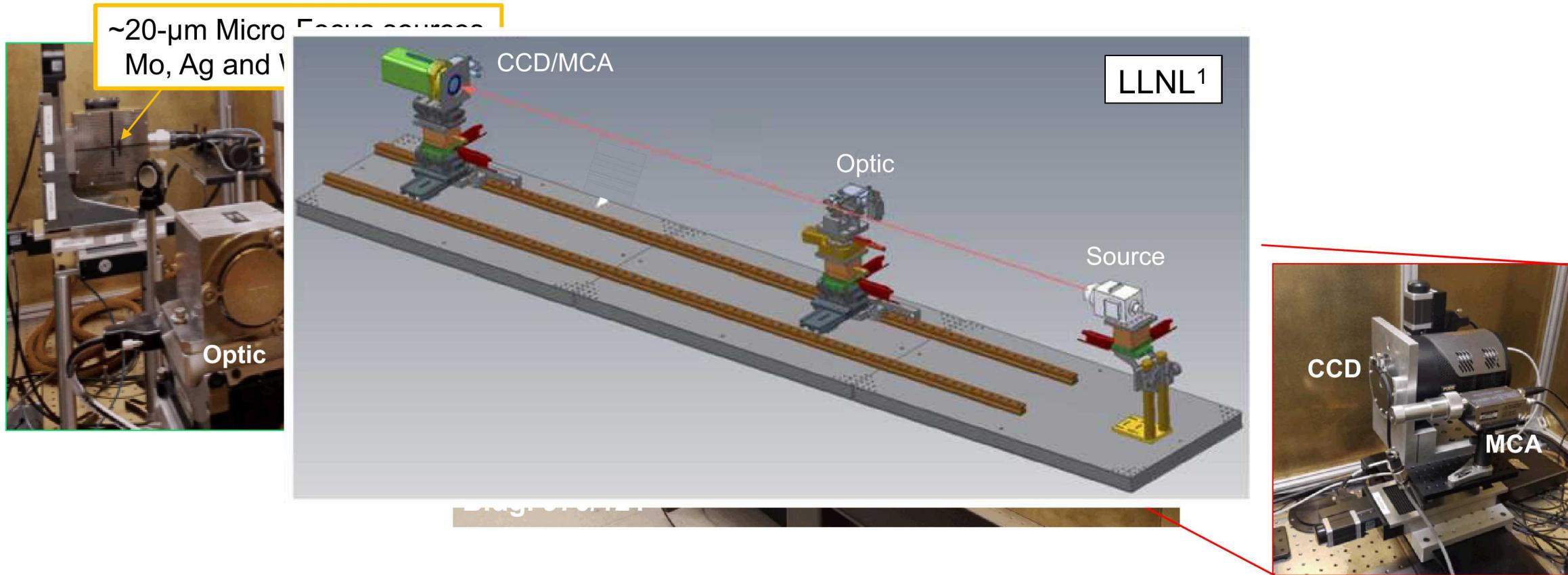
Simulated image from 3D source:



Upcoming experiments will synthesize information from spatially and spectrally resolved diagnostics at multiple lines of sight

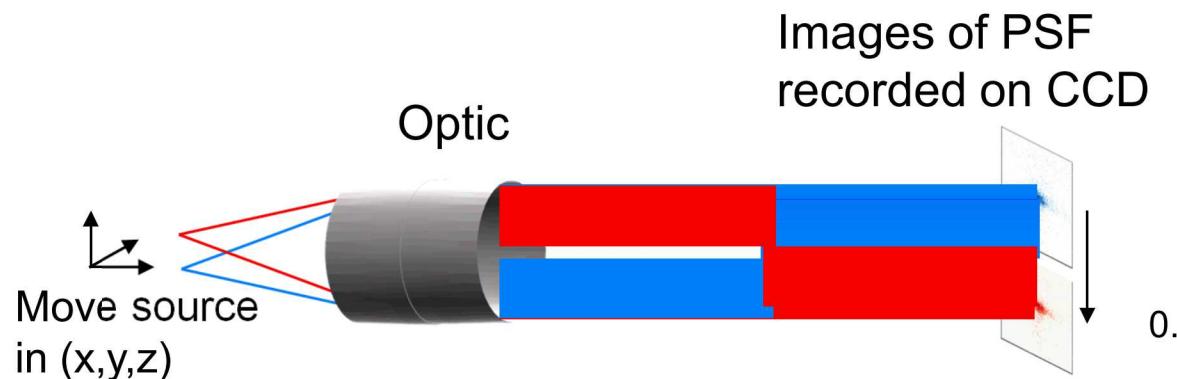


We developed facilities at LLNL¹ and SNL² to record calibration measurements for image processing and to inform fielding decisions



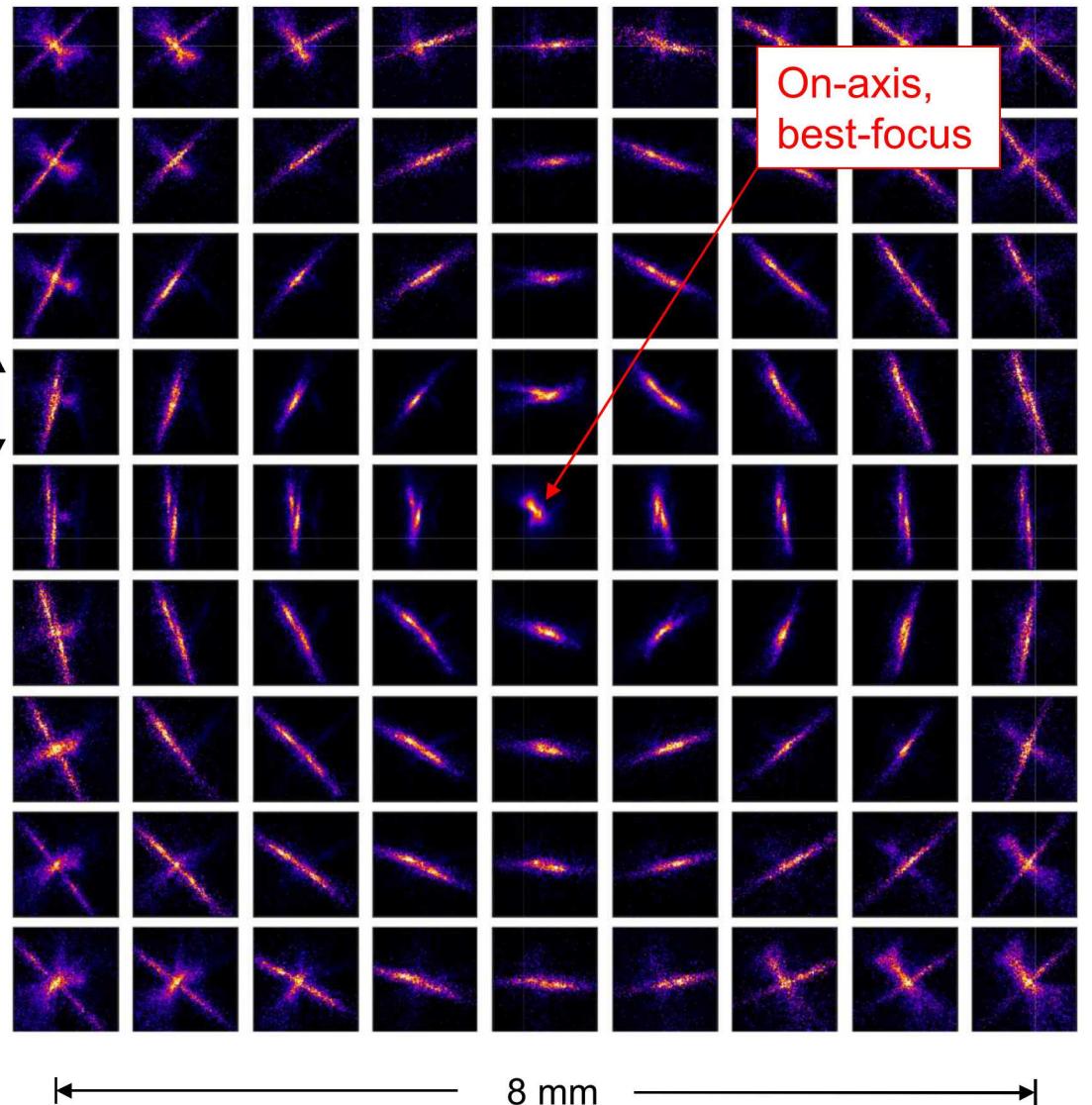
- Resolution/point-spread function over FOV
- Spectral reflectivity, throughput/illumination over FOV
- Monitor performance degradation (if any) post-shot

Imaging of a ~point source demonstrates resolution between 75 – 300- μ m over a >5x5x5 mm³ field of view



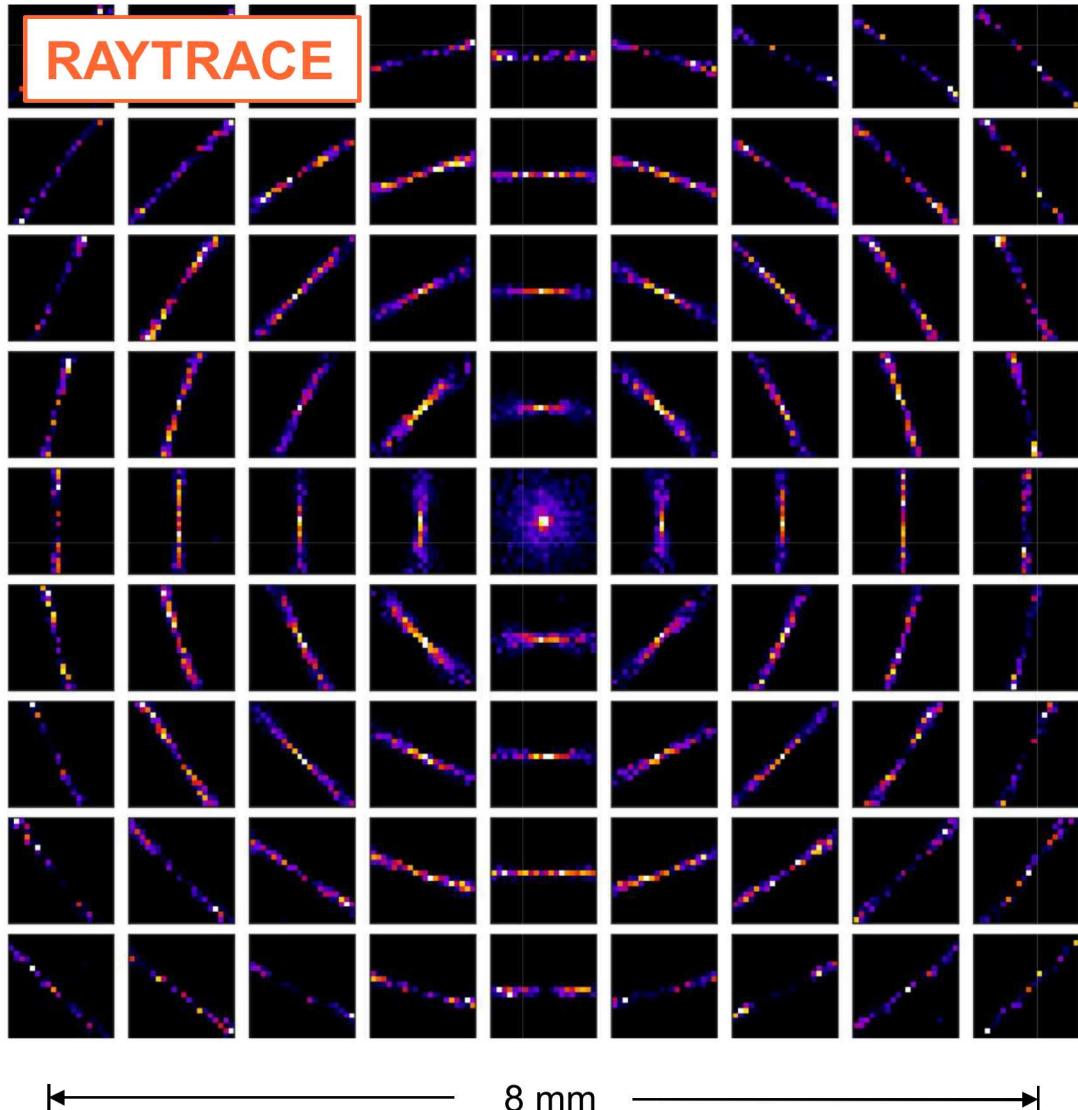
- 75- μ m resolution on-axis
- 30- μ m x 300- μ m resolution off-axis
- Depth of field ~ 1 mm

Measured PSF map at plane of best-focus:

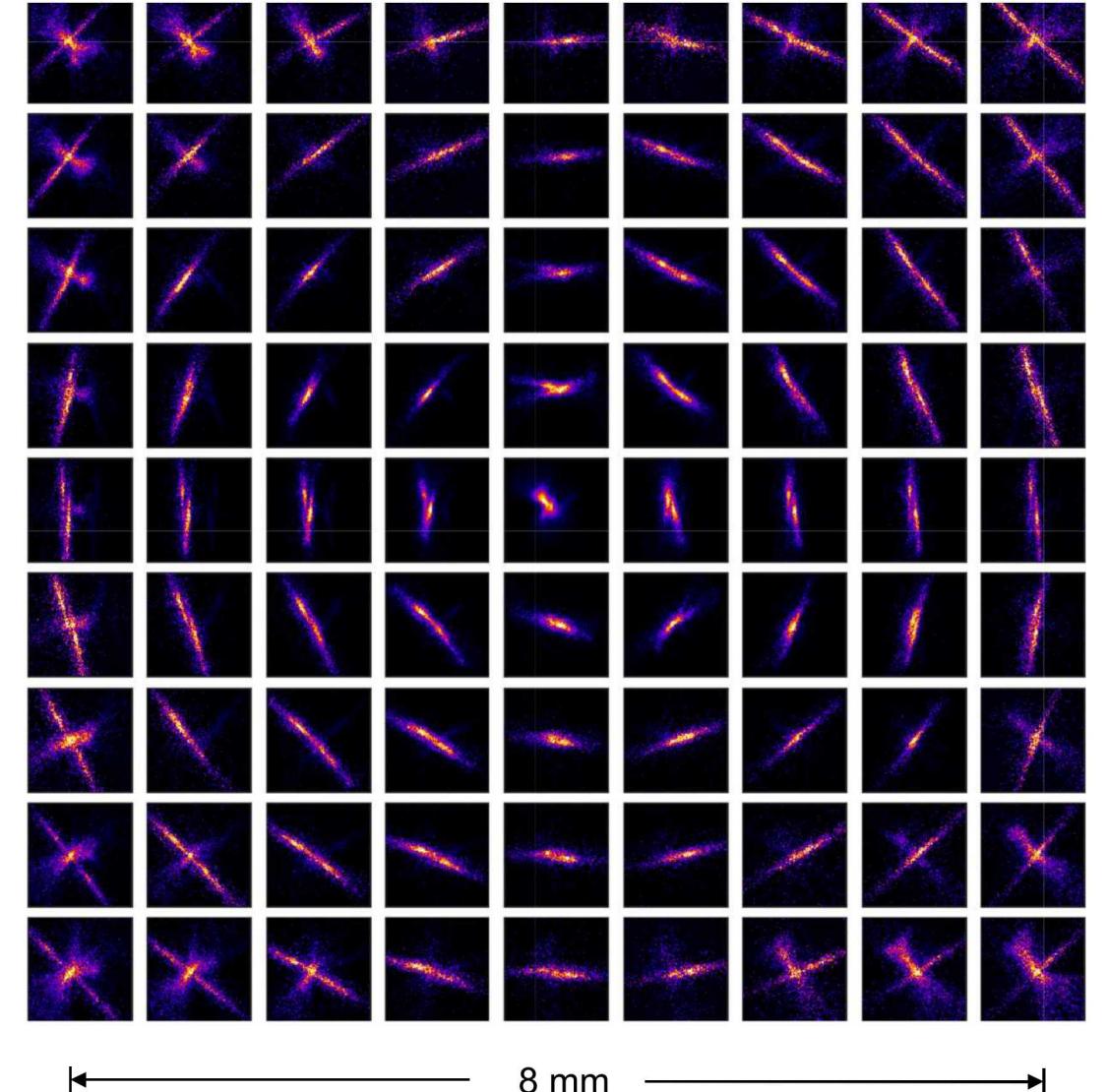


Measured PSFs agree with raytrace simulations, with deviations likely from optic figure error

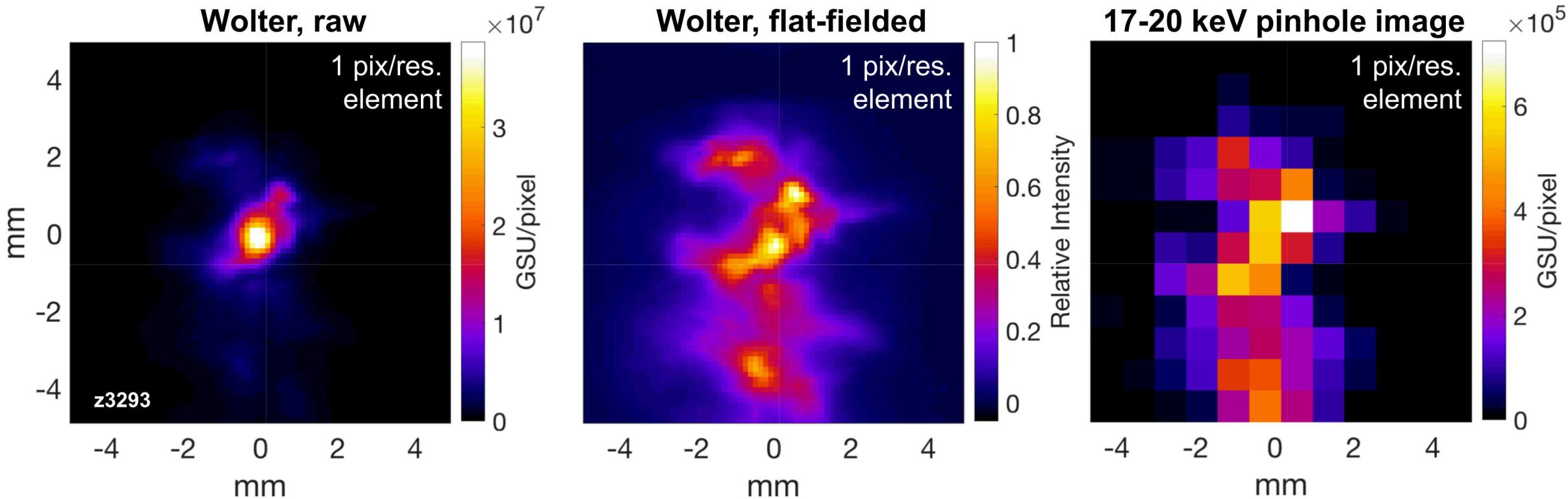
28



Measured PSF map at plane of best-focus:

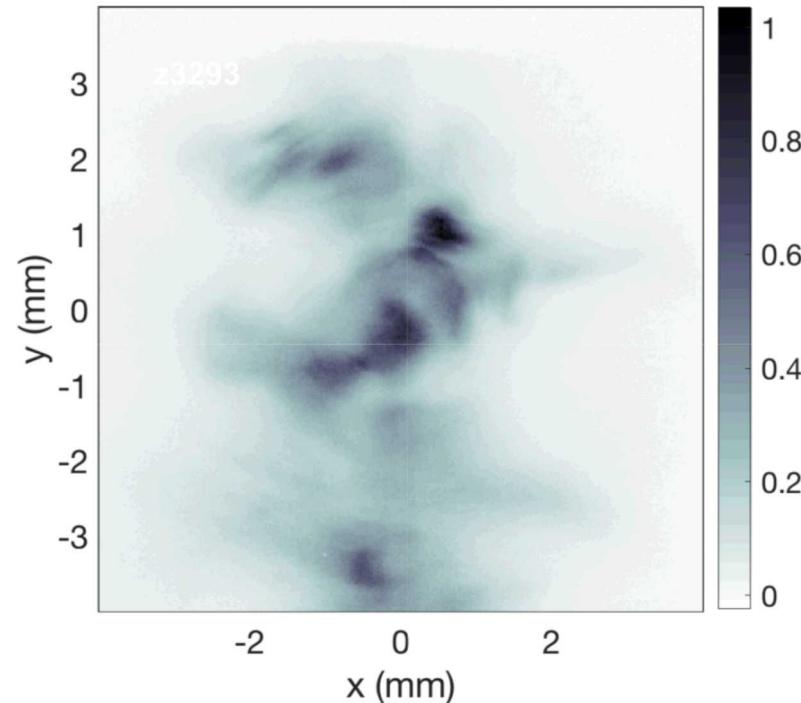


First Wolter images¹ demonstrate drastic improvements in spatial resolution and signal/noise compared to pinhole camera²



- Flat-fielded Wolter images have features similar to those seen in time-integrated pinhole camera² (TIPC) images
- Wolter demonstrates spatial resolution better than 150 μ m, compared to \sim 1 mm in TIPC, as well as a factor of 19 – 64 increase in signal/noise (helps enable time-resolved)

We are beginning advanced image processing to efficiently calculate Wolter images and deblur them



Shift-variant PSF

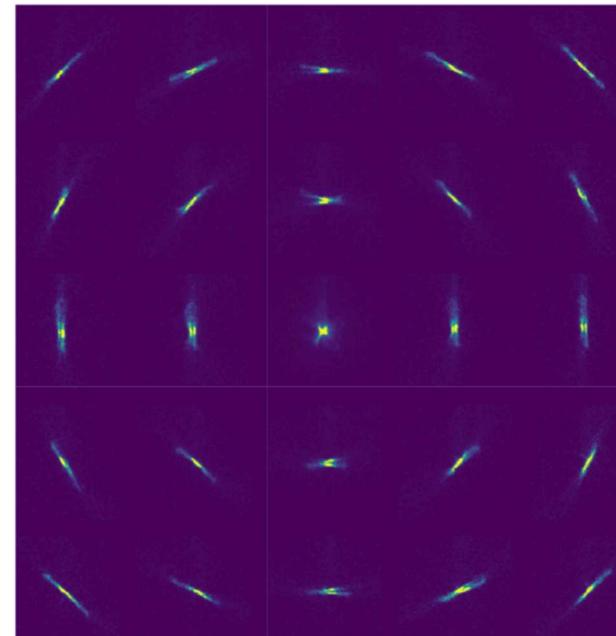


Image is computed as sum of convolutions over PSF modes after interpolating coefficients, $a_p(s)$ at all source positions

PSF

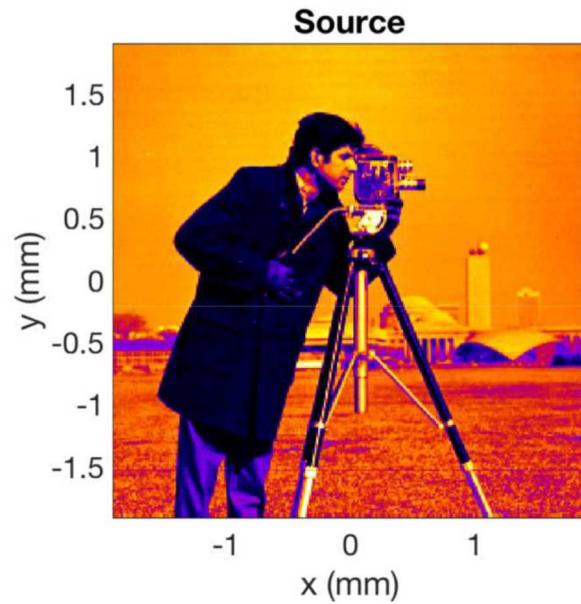
$$k(r, s) = \sum_p^N a_p(s) c_p(r - s)$$

Coefficients (vary over FOV)

p^{th} shift-invariant PSF mode

A Wolter image of a source can be computed using measured PSF data

31



Iterative deblurring
(e.g. Lucy-Richardson)

$$\text{Image} = \sum_p^N c_p * (a_p \times \text{Source})$$

$$I_n = S_n * K$$
$$C_n = \left(\frac{I}{I_n} \right) * K^T$$
$$S_{n+1} = C_n S_n$$

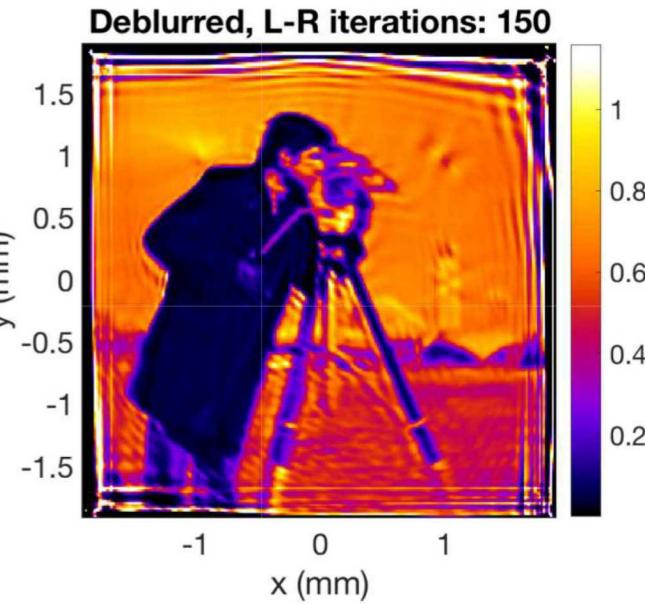
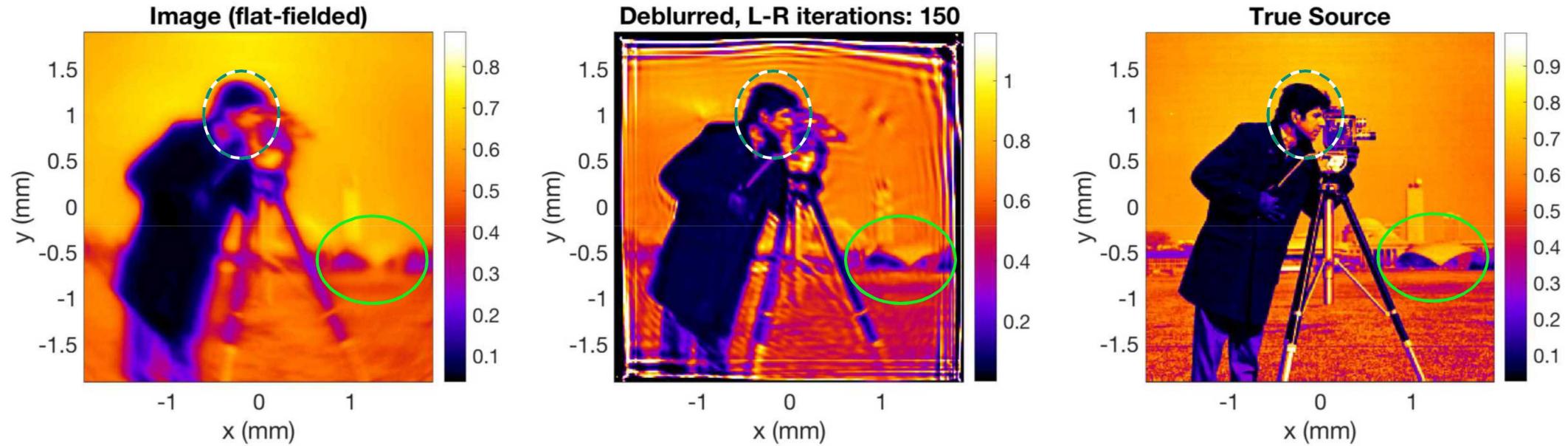


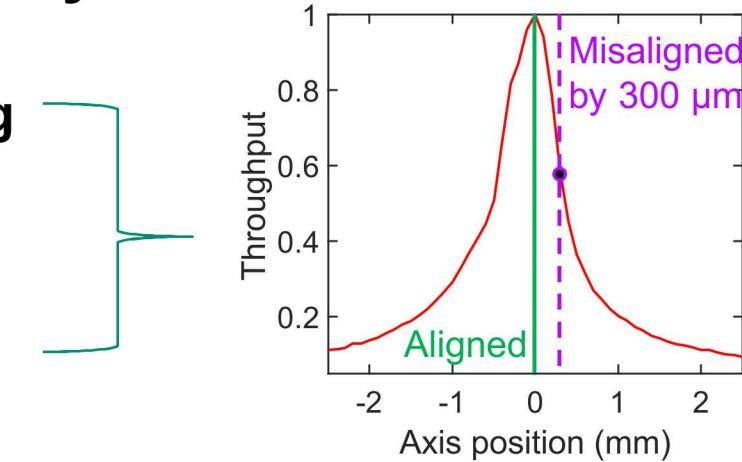
Image deblurring shows potential to recover sub-resolution structure and improved contrast in the source distribution



The Wolter optic's spatially-varying response presents challenges for both instrument fielding and image analysis

- **Variation of throughput over FOV requires flat-fielding**

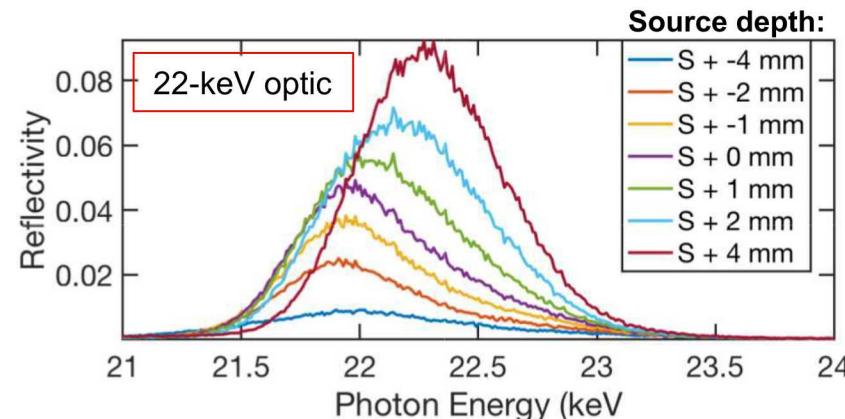
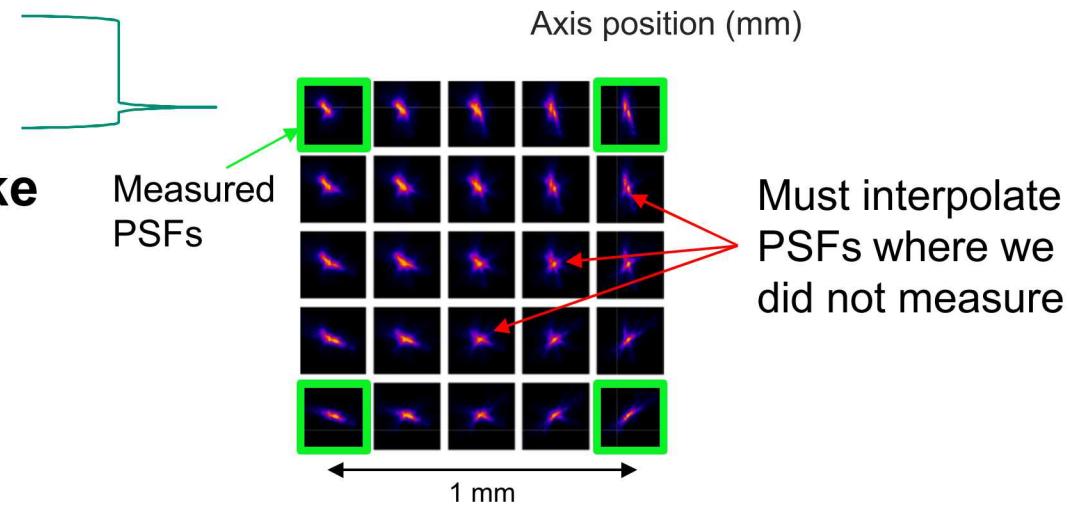
- In image, need to distinguish between high throughput and actual source intensity
 - Alignment must be better than 0.05 deg. and 200 μm



- **PSF is shift-variant (spatially-varying):**

- convolutions/deconvolutions w/FFTs don't work for deblurring

- **Optic's response is different at each depth (unlike simpler pinhole camera)**

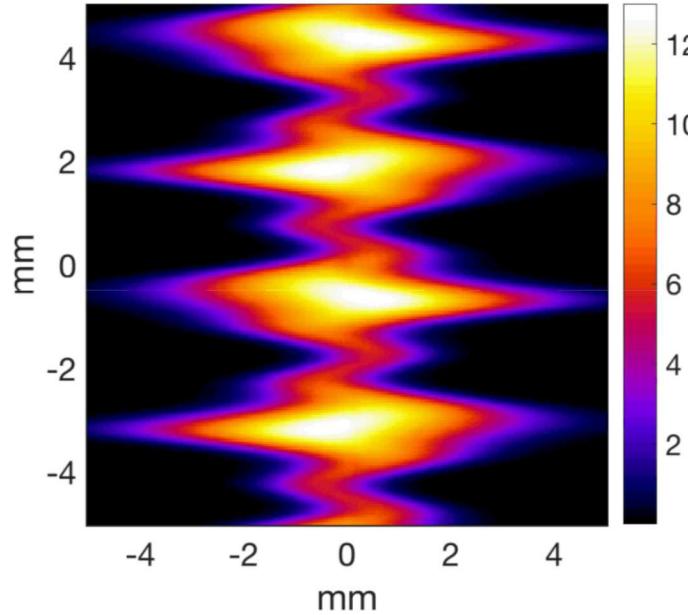


Flat-fielding without a 3D model of the source can accurately produce images with uniform sensitivity (e.g. pinhole camera)

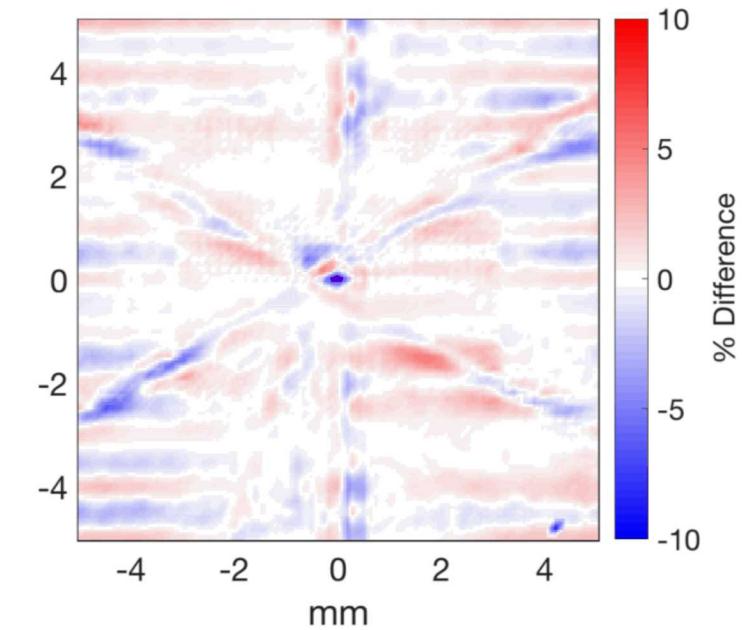
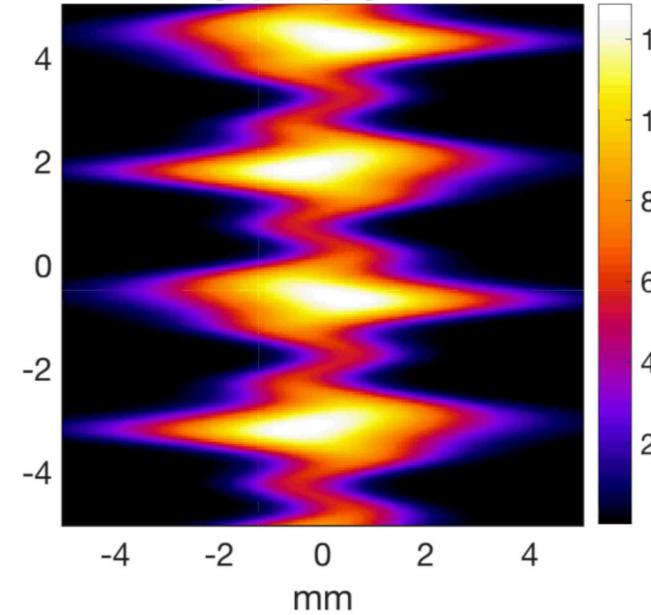


Simulated images (no blurring):

Wolter, Flat-fielded



Uniform Throughput (e.g. Pinhole Camera)

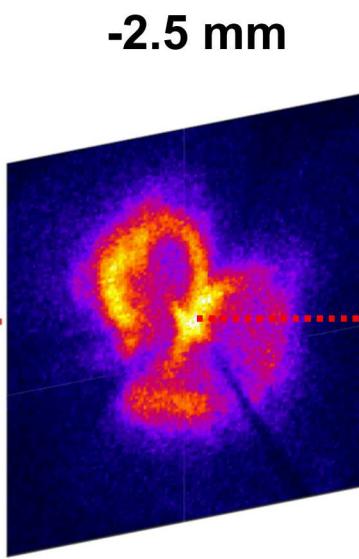
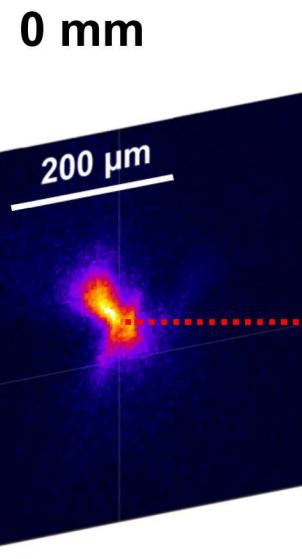
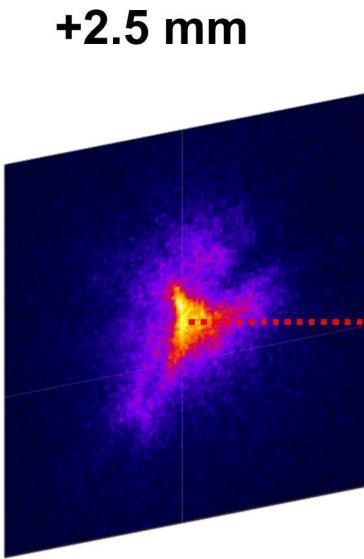


$$\text{Image}(x, y) = \int \text{Source}(x, y, z) T(x, y, z) dz$$

$$\text{Pinhole image} = \int \text{Source}(x, y, z) dz \approx \frac{\text{Image}(x, y)}{\frac{1}{\Delta z} \int T(x, y, z) dz}$$

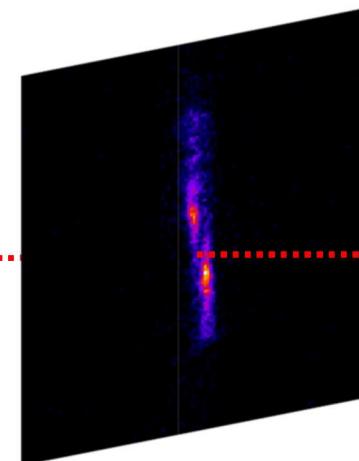
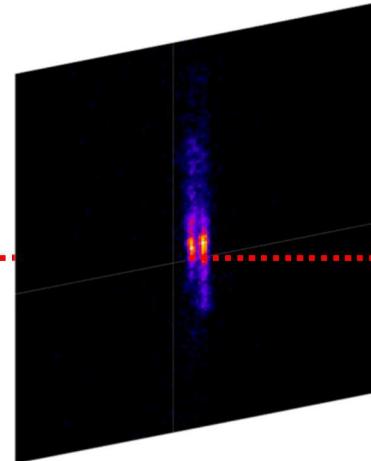
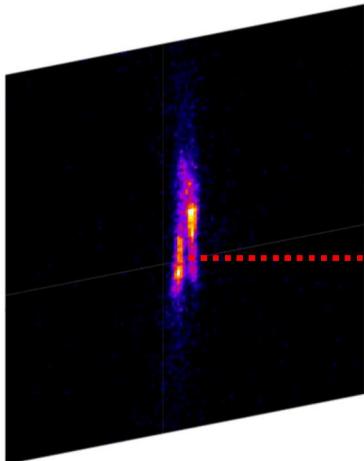
The optic's PSF also varies significantly with depth

On-axis:



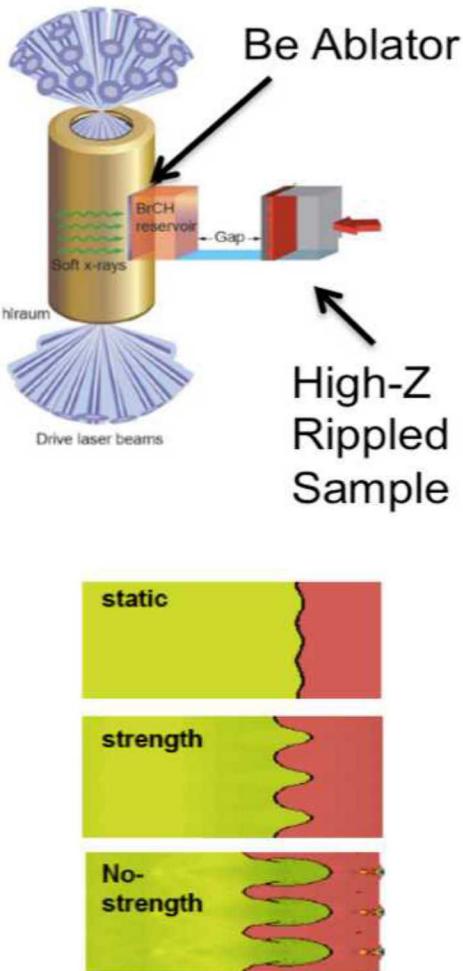
Increasing
source-optic distance

2 mm
off-axis:



Future Wolter optics will enable multi-frame, high contrast imaging with ~5- μ m resolution on NIF

RT Strength Platform



Backlight with x-rays up to 60 keV in energy and image at high resolution with a Wolter optic

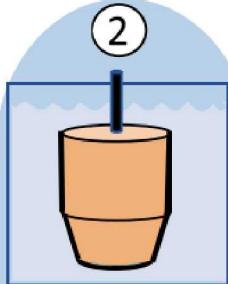
- **~40x increase in signal from large solid angle**
- **Narrowband response improves contrast by reducing out-of-band signal**
- **Enables multi-frame imaging**

Spec.	Sandia 1 st generation	NIF 1 st generation	NIF 2 nd gen
Resolution	100 μ m	5 μ m	5 μ m
FOV	5 mm	0.5 mm	1 mm
Magnification	3.5	10	10-20
Energy	17-23 keV	<=25 keV	50 keV

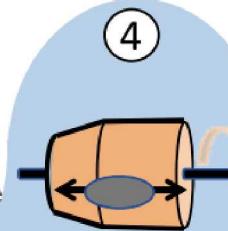


Fabrication of Mandrel

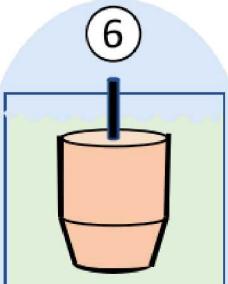
1. Cut mandrel from aluminum bar using CNC machine



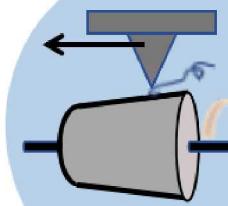
3. Precision diamond turning to 20 Å surface finish and submicron figure



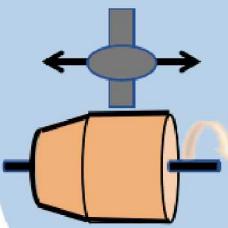
5. Check mandrel quality via metrology measurements



2. Chemical cleaning and activation & electroless nickel plating

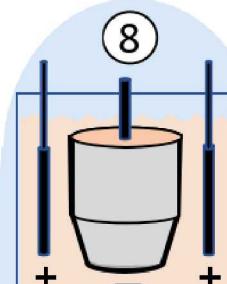


4. Polishing and super-polishing to 3-4 Å root mean square surface finish

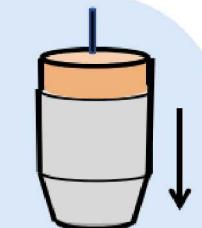


Fabrication of Shell

7. Deposition of multilayers on mandrel in coating chamber



9. Separation of optic from mandrel in cold water bath

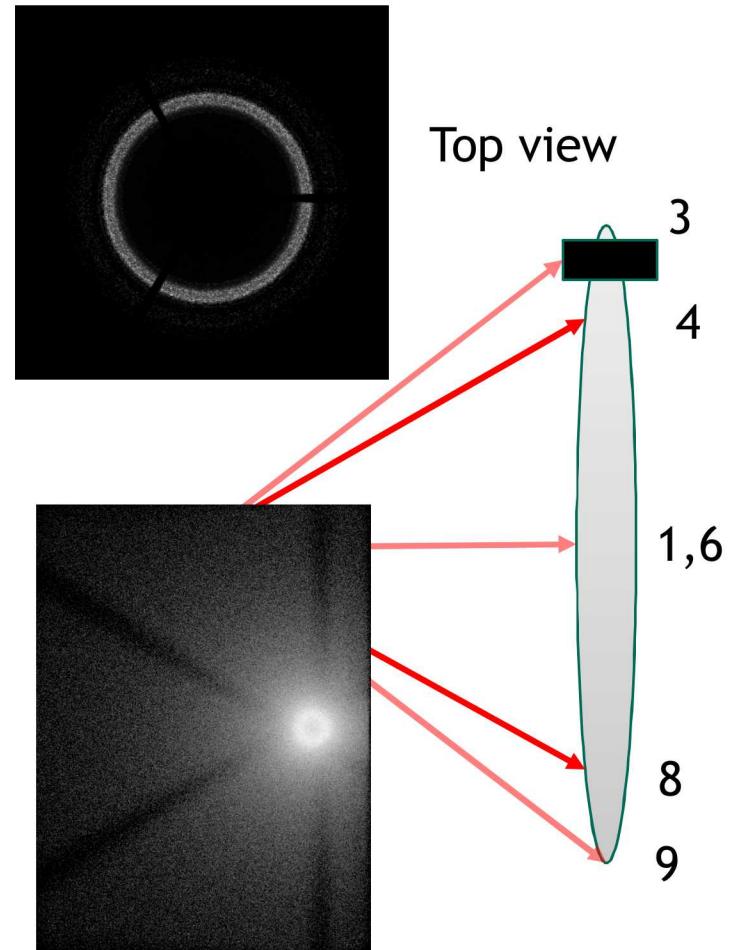
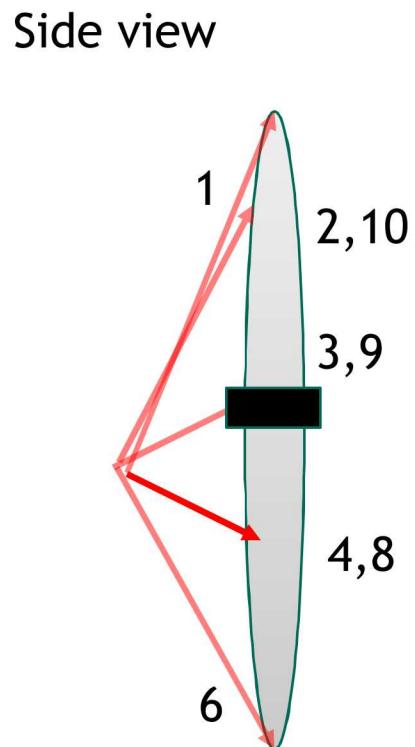
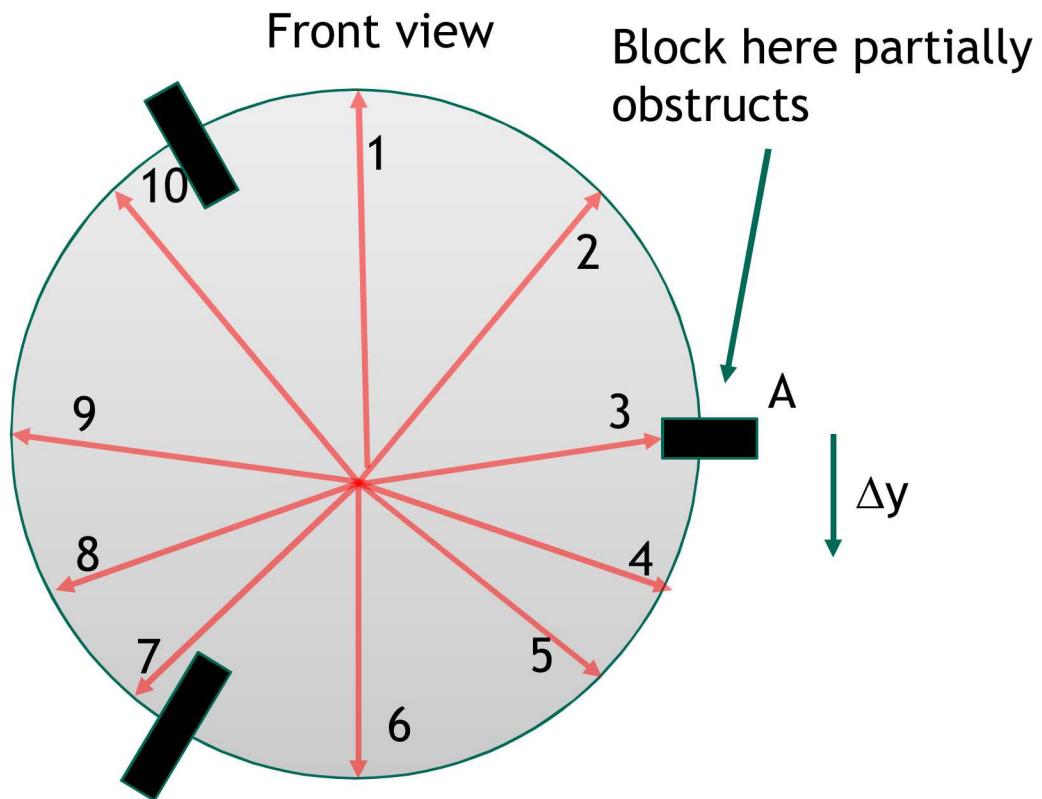


6. Ultrasonic cleaning and passivation to remove surface contaminants



8. Electroforming of Ni/Co shell onto mandrel with multilayer

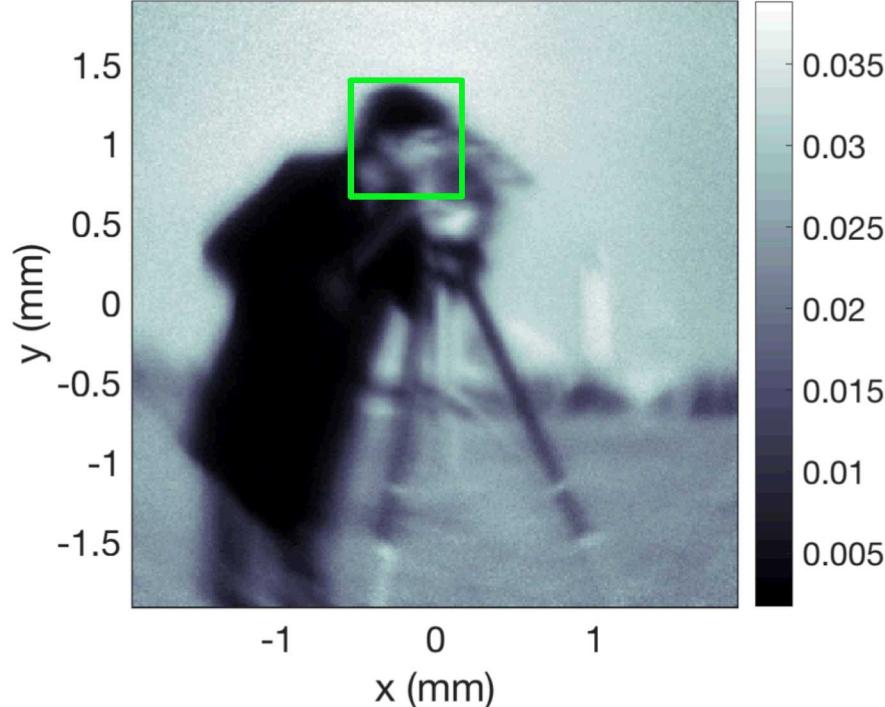
Moving off-axis causes the rays to no-longer meet Bragg condition in the direction of movement



- Rays orthogonal to the movement direction still meet the Bragg condition
- Obscuration “A” blocks rays when the source is moved in either +- y direction so it shows up two times in the throughput map

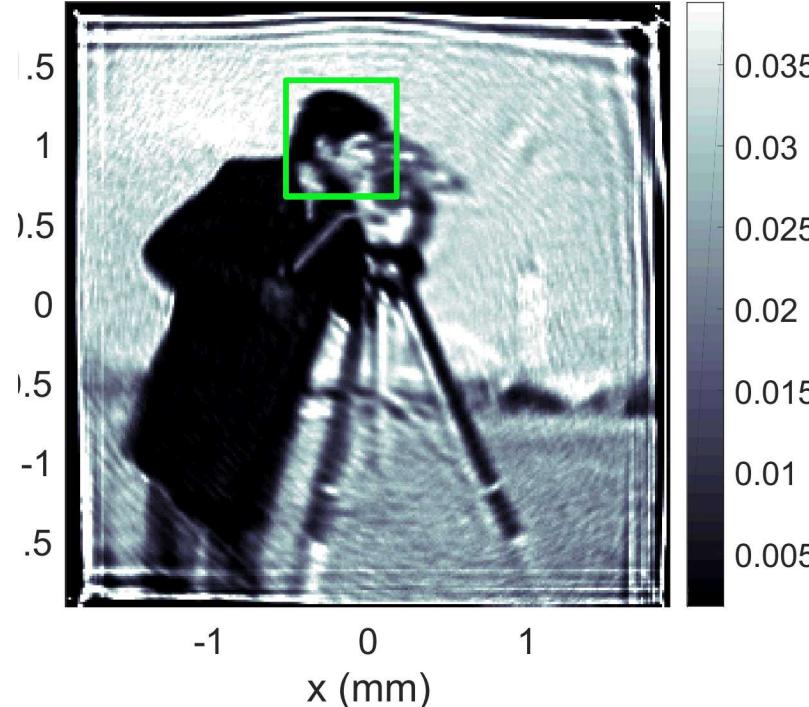
Deblurring with noise

Image (flat-fielded)



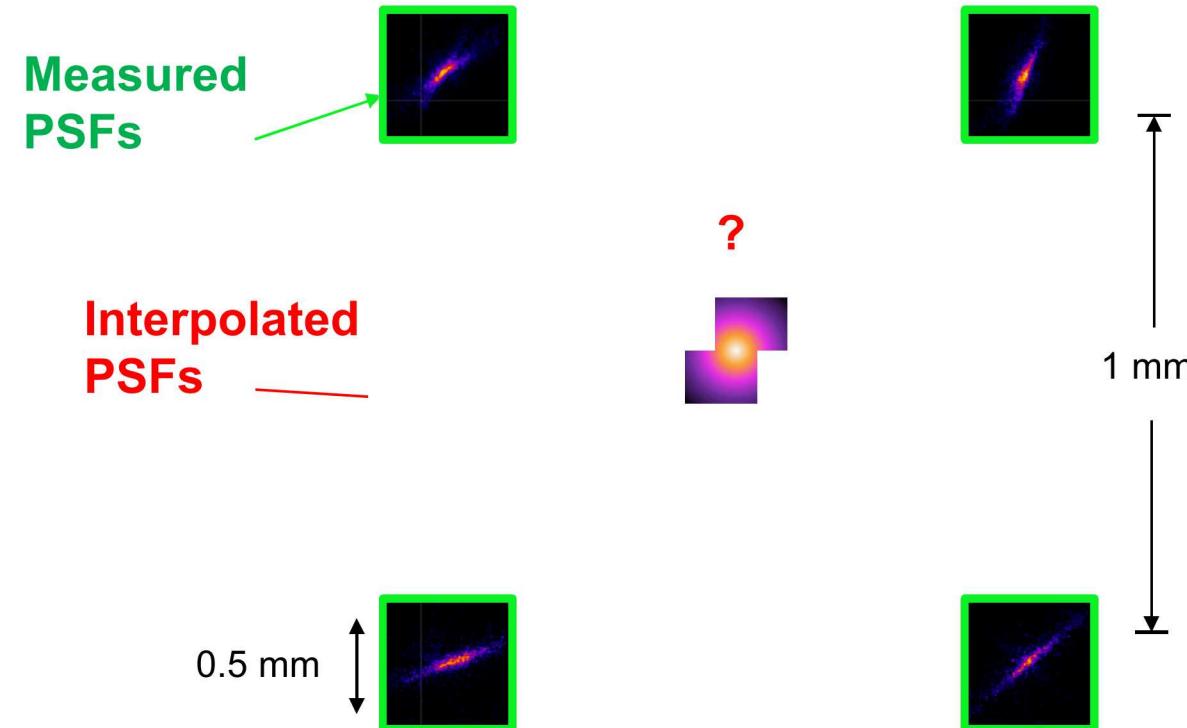
144% mean difference

Deblurred, L-R iterations: 100



44% mean difference

Decomposition enables interpolation of PSFs at all source positions for image computation



- **Image is computed as sum of convolutions over PSF modes after interpolating coefficients at all source positions:**

$$\text{Image} = \sum_p^N c_p * (a_p \times \text{Source})$$

Many people have contributed to Wolter...

Science needs, system performance: Dave Ampleford (previous RS), Jeff Fein (current RS), Ming Wu

Engineering design: Chris Ball, Paul Gard (detector subsystem), Andy Maurer (optic subsystem)

SNL Calibration: Ming Wu, Jeff Fein, Pat Lake

Hardware buildup: Pat Lake, Mike Sullivan, Chris Kirtley, Linda Nielsen-Weber, Andy Maurer

Hardware prototyping: Larry Lucero

Stage control: Drew Johnson, Jeff Georgeson, Chris Ball

Calibration/commissioning lab build up: Pat Lake, Ming Wu, Paul Gard

Commissioning and System demonstration: Pat Lake, Dave Ampleford, Jeff Fein, Chris Ball

Fielding in Z: Mike Sullivan, Chris Kirtley, Aaron Citrin, Chris Ball, Dave Ampleford, Jeff Fein, Linda Nielsen-Weber, Antoinette Maestas, Brian Ritter, Dan Folker

Image Analysis: Jeff Fein

Management: Clark Highstrete, Greg Dunham, Chris Bourdon (start of project), Greg Rochau (NDWG)

Thanks to the Z Diagnostics and Operations teams!

External:

Optical design: Julia Vogel, Bernie Kozioziemski, Chris Walton (*LLNL*)

Optic fabrication: Suzanne Romaine, Drew Ames (*Harvard/Smithsonian Center for Astrophysics*)

Optic mounting and testing: Brian Ramsey, Kiranmayee Kilaru (*NASA Marshall Space Flight Center*)

LLNL Calibration: Bernie Kozioziemski (*LLNL*)